

Self-organization on surfaces: an overview

O.Fruchart



Laboratoire Louis Néel, Grenoble, France.

<http://lab-neel.grenoble.cnrs.fr/themes/couches/ext/>

(1. Introduction)

-  **2. Self-assembled epitaxial growth**
-  **3. Self-organized epitaxial growth**
-  **4. 3D self-organization via multilayer stacking**
-  **5. Perspectives of self-organization**
-  **6. X-ray investigation of SO systems**

References

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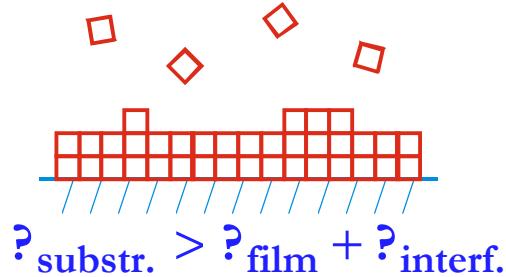
References



Macroscopic concept: surface energies

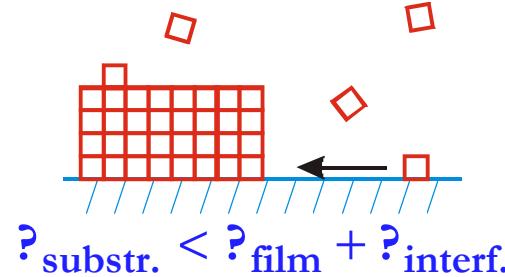
2D

Franck van der Merwe



3D

Volmer-Weber



E.Bauer, Z.Kristallogr.110, 372 (1958)

E.Bauer, Phys.Rev.B 33, 3657 (1986)

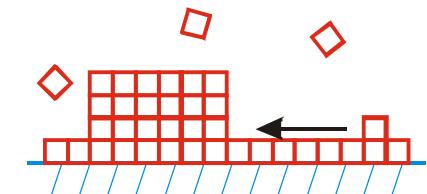
- Flat thin films: **high** substrate energy
- Islands (dots): **low** substrate energy



Another growth mode is frequently observed

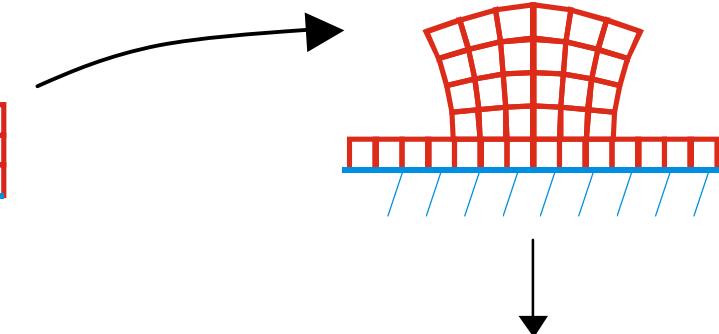
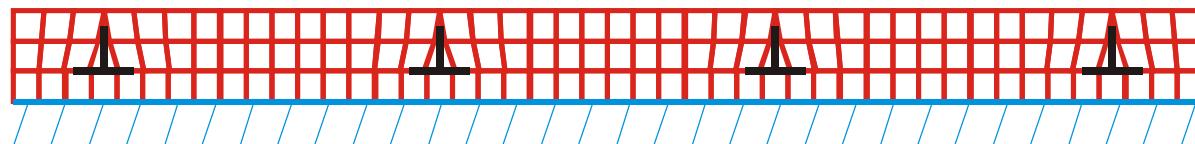
2D → 3D

Stranski-Krastanov

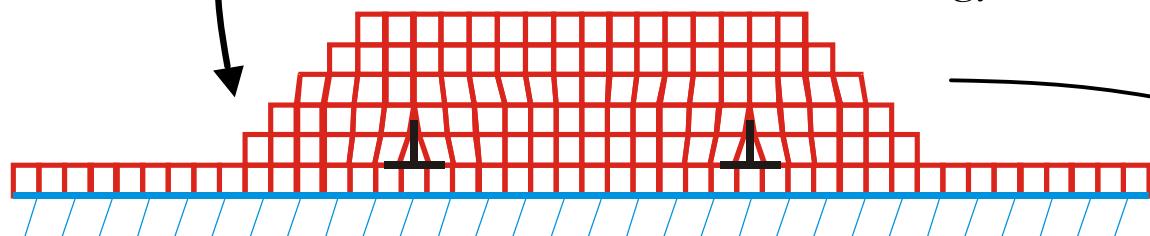


Microscopic concept: misfit accomodation

- High energy of dislocations



Additional effective interface energy



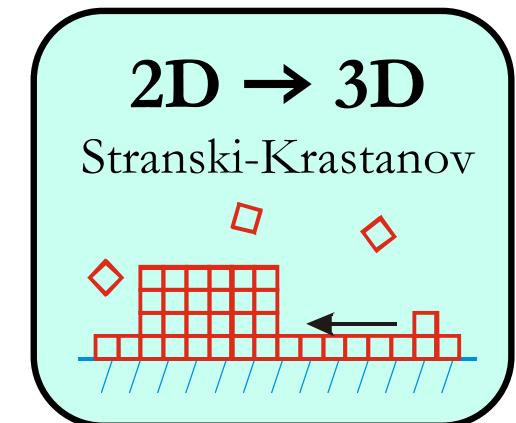
P.-O. Jubert et al., Phys. Rev. B 64, 115419 (2001)

F. Tinjod et al., submitted to J. Alloy Comp. (2002)

- Thickness-dependant surface stress

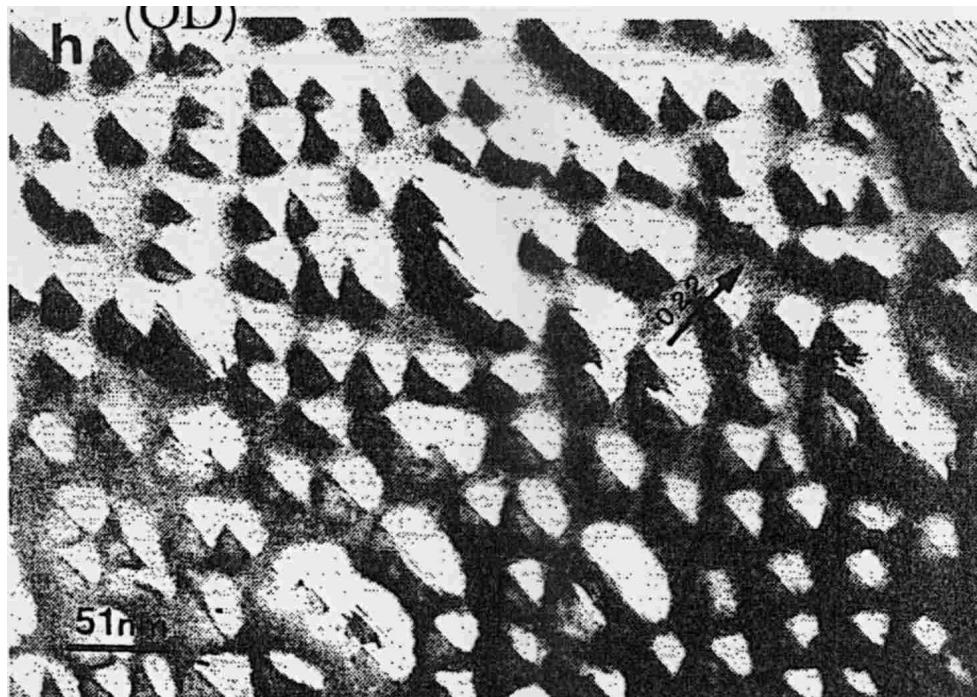
H.Ibach, Surf.Sci.Rep.29, 193 (1997)

Misfit accomodation
by elastic 3D relaxation



- Many parameters for spontaneous island growth:
Self-assembly

► In_xGa_{1-x}As/GaAs quantum dots (OD)



S.Z.Chang et al., J.Appl.Phys.73,4916(1993)

↳ Laser diodes

Improvements : $\frac{?L}{L} \approx 4\%$

Nishi et al., Appl.Phys.Lett.74, 1111(1999)

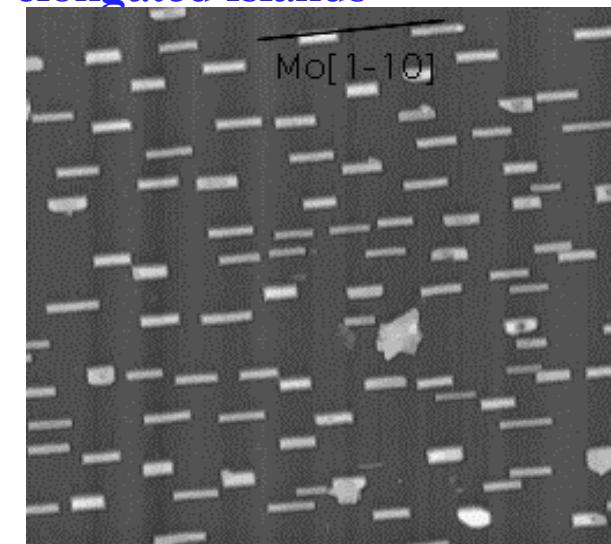


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► Fe/Mo(110) elongated islands

6 μm

SEM

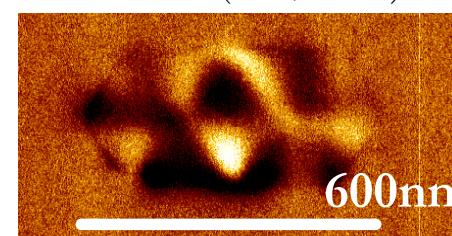


AFM

MFM.

Coll. Y. Samson

(CEA/France)



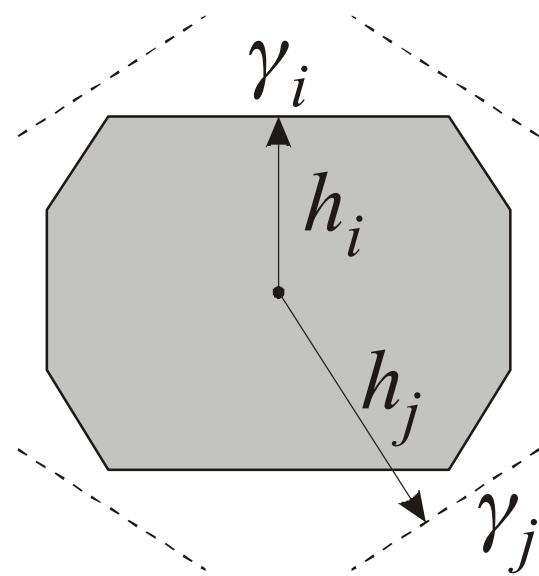
Target : Fe

P.-O.Jubert et al., LLN.

Wulff's theorem

Free crystal

$$\frac{\gamma_i}{h_i} = \text{Constant}$$

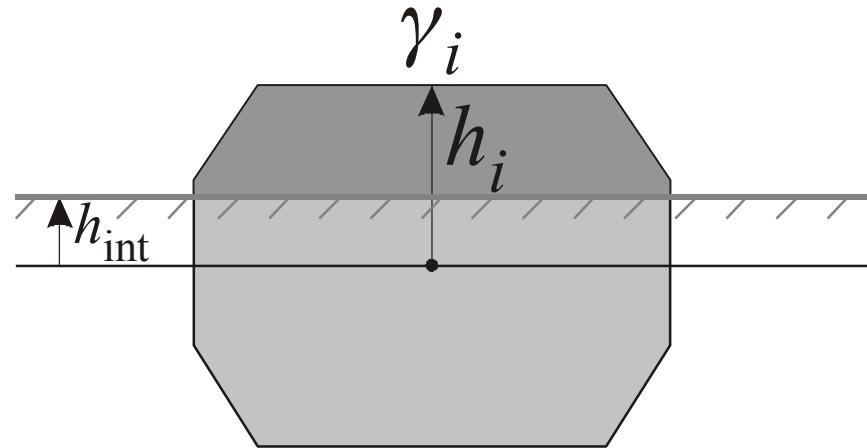


No facets with high surface energy

Wulff Kaishev's theorem

Supported crystal (growth on surfaces)

$$\frac{\gamma_i}{h_i} = \frac{\gamma_s - \gamma_{\text{int}}}{h_{\text{int}}} = \text{Constant}$$

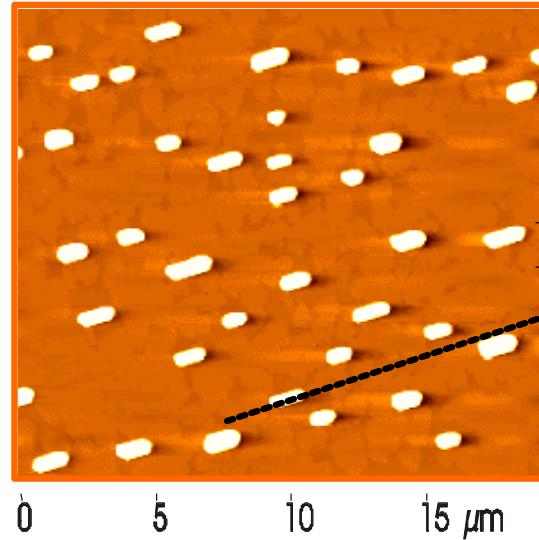


Truncated crystal

With strain:

Simulations or more complex models (e.g. small dots)

P. Müller and R. Kern, Surf. Sci. 457, 229 (2000)

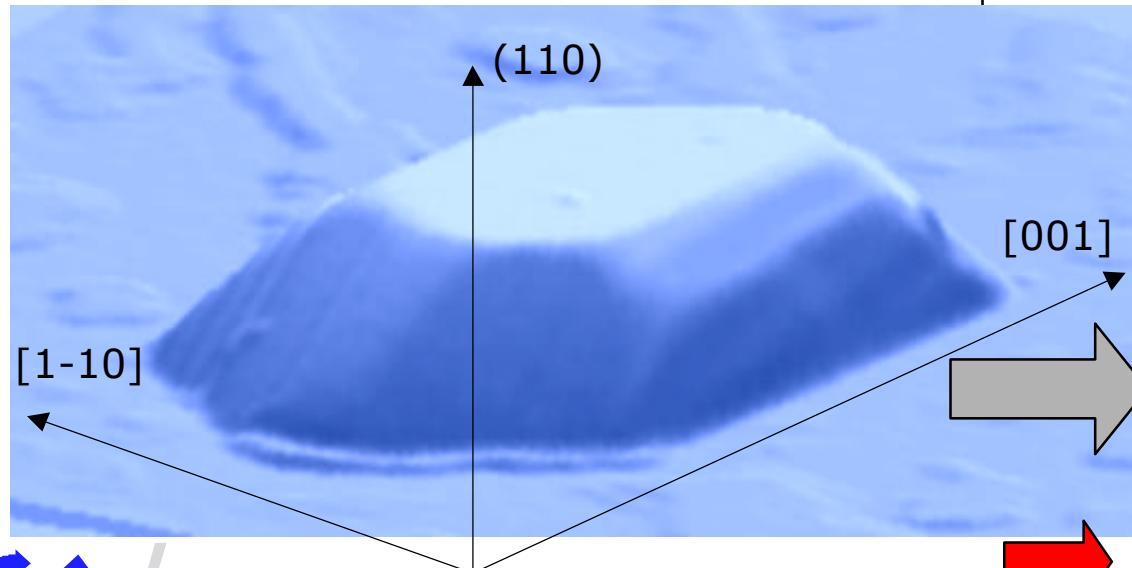


Fe/Mo(110)

Fe[001]

0 5 10 15 μm

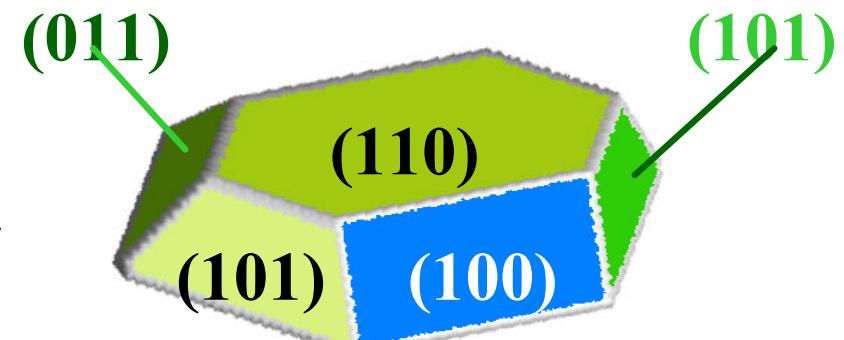
AFM, 18mmx18mm



Sample



RHEED beam



Model magnetic system



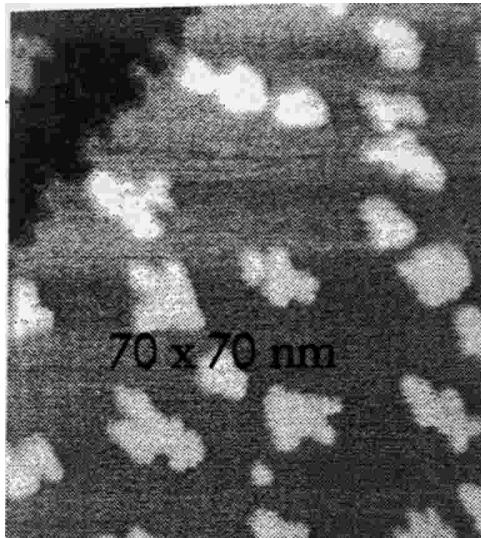
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Olivier Fruchart - 2/09/2003 - p.9

Very general phenomenon : many systems are suitable.

- Parameter : coverage $0 < x < 1$

Fe/W(110)



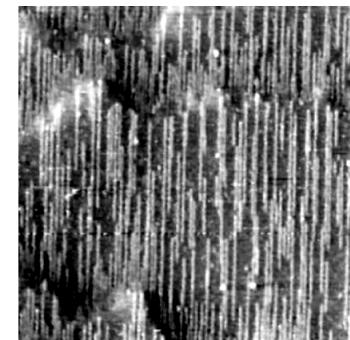
H.J. Elmers et al., Phys. Rev. Lett. **73**, 898 (94)

« Test of scaling theory at a two-dimensional Ising-like transition »

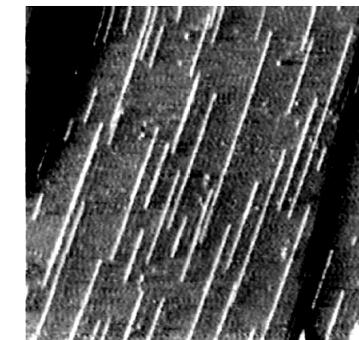
Ch. Würsch et al., J. Magn. Magn. Mater. **177-181**, 617 (1998).

- Parameters: substrate symmetry and temperature

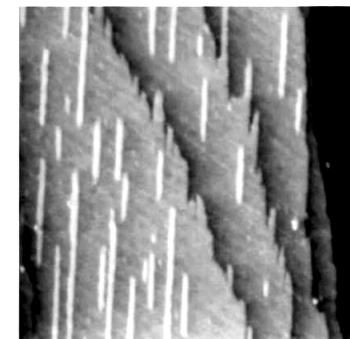
a) $T = 265 \text{ K}$



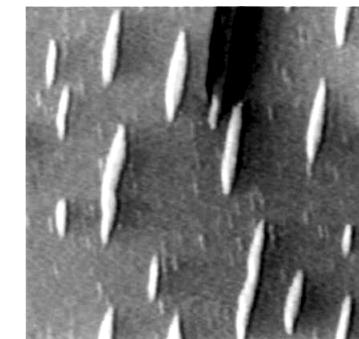
b) $T = 300 \text{ K}$



c) $T = 320 \text{ K}$



d) $T = 350 \text{ K}$



Cu/Pd(110)

500 Å

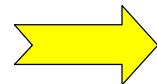
J.P. Bucher et al., Europhys. Lett. **27**, 473 (93)



Size and density of the dots can be tuned nearly independently

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↳ Self-assembly + 'long-range' positional order between dots.

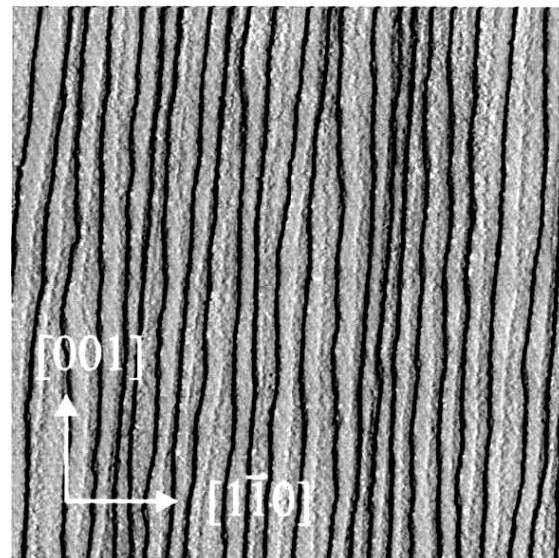
Dot-dot interactions << dot-substrate : the organization must be supplied by the substrate

STEP DECORATION

- Array of **atomic steps**. Ex: stripes (1D)

Vicinal
Fe(110)/W(110)

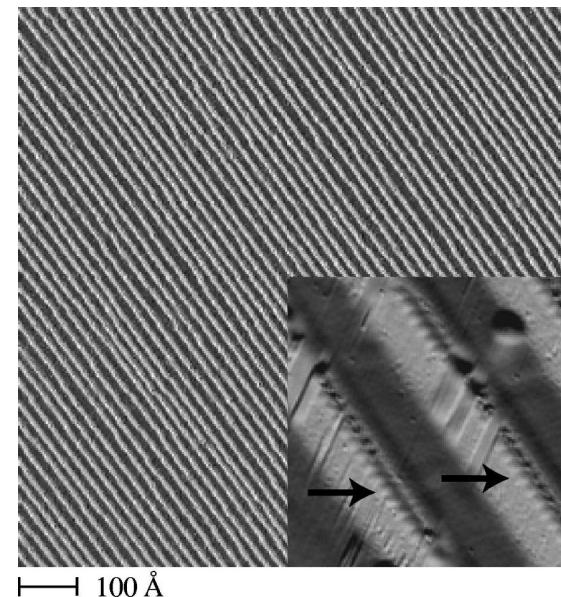
250 x 250 nm



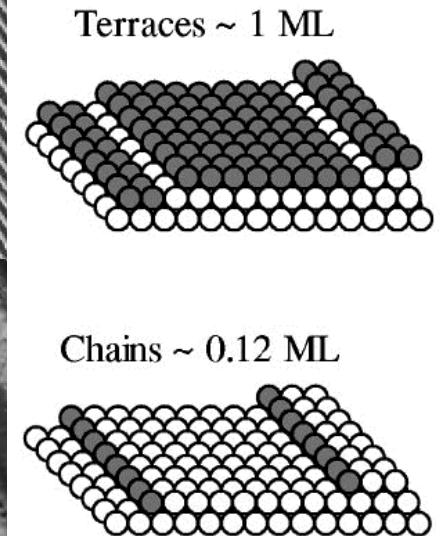
J.Hauschild et al., Phys.Rev.B57, R677(1998)

- ↳ Magnetic order in 1D
(stabilized by dipolar interactions)

- Ex: Stripes and wires (1D)



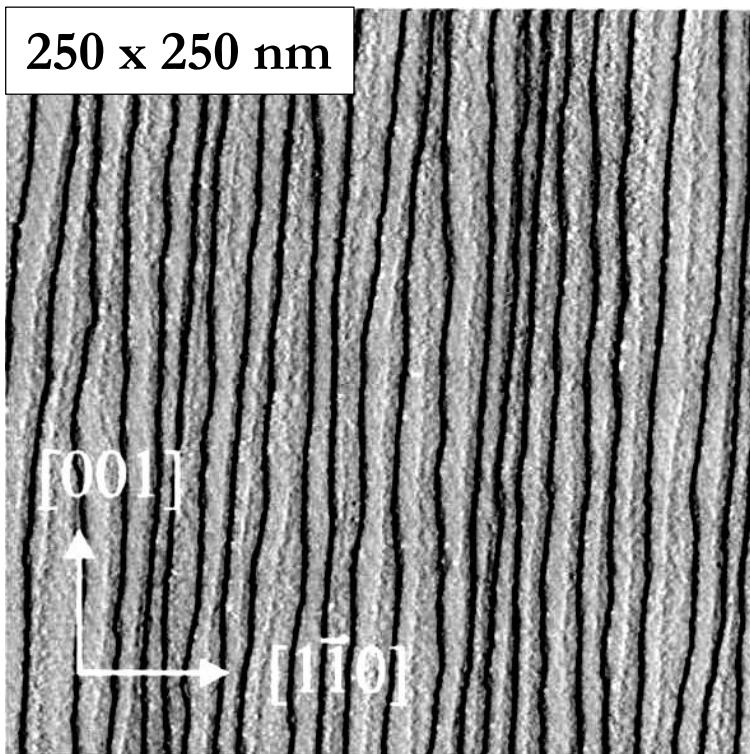
A. Dallmeyer et al., Phys.Rev.B 61(8), R5153 (2000).
Co(250K - 0.12ML)/Pt(997)



- ↳ Magnetic order and anisotropy in 1D

Example: Vicinal
Fe(110)/W(110)

Thickness = 0.5AL



T_c=179K

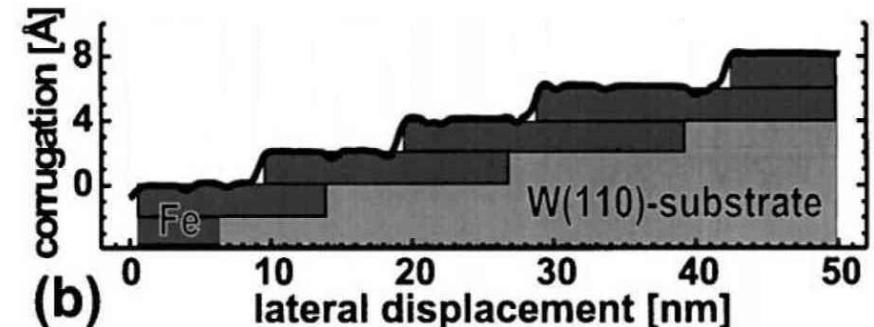
Magnetic ordering
in 1D
(stabilized by
dipolar interactions)

J.Hauschild et al., Phys.Rev.B57, R677(1998)

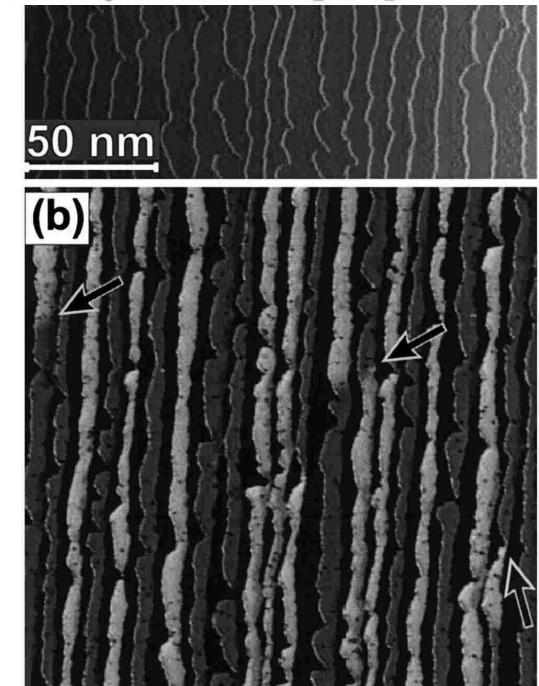


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Thickness = 1.5AL

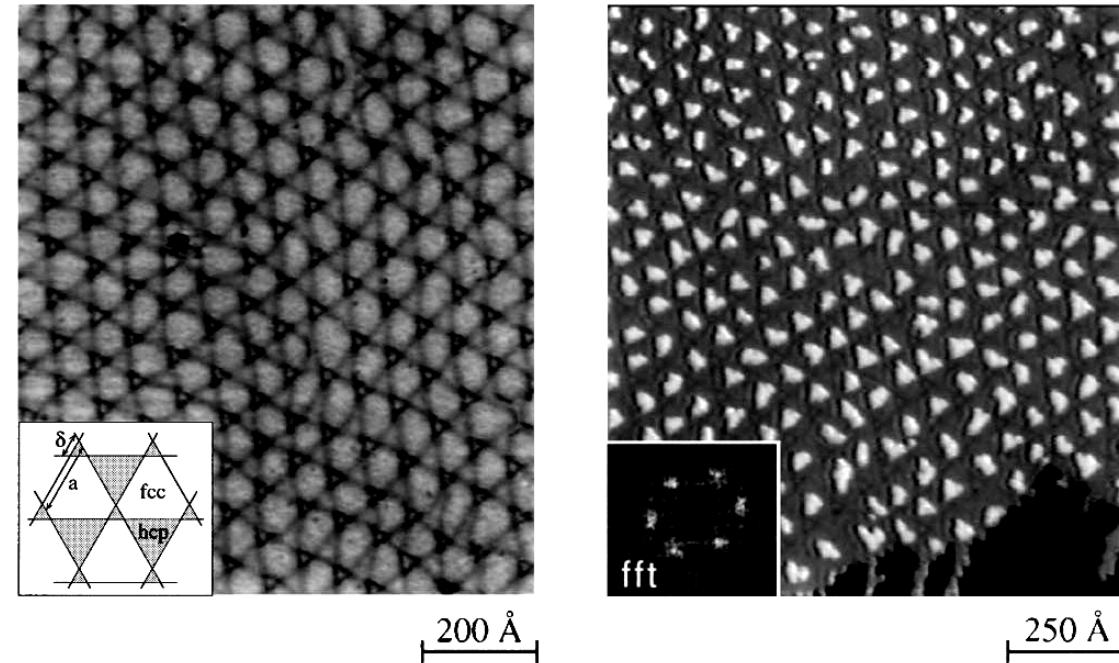


Spin-
Polarized
Scanning
Tunneling
Spectroscopy
(low temp.)



M. Bode et al, J. Electr. Spectr. Rel. Phenom. 114– 116, 1055 (2001)

➤ a) Overlayer dislocations array. Ex: dots (OD)

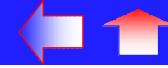


H.Brune *et al.*, Nature **394**, 451 (1998)

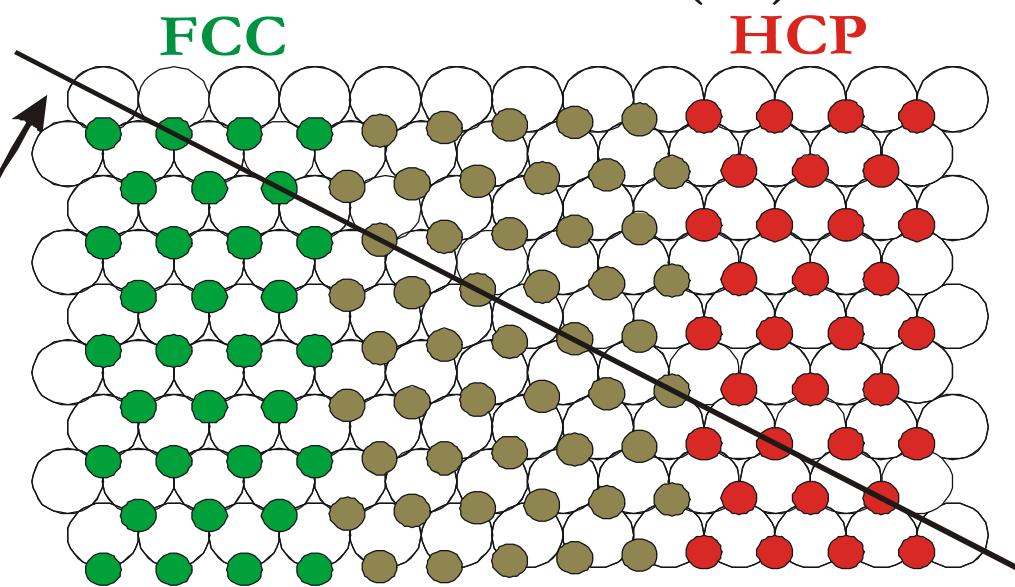
Ag(110K)/Ag(2ML, 400K annealed at 800K)/Pt(111)

➤ Also : improvement of size uniformity of the dots

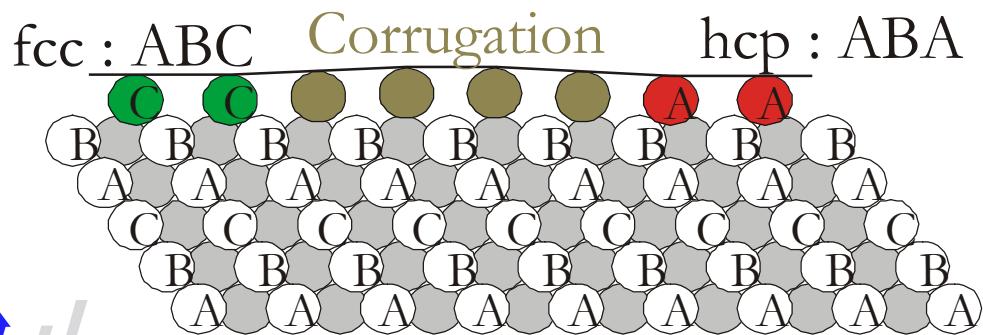
D.Y.Petrovykh, Surf.Sci. **407**, 189 (1998)



Planar view of Au(111)



Cross-sectional view



Second layer atoms

Site B

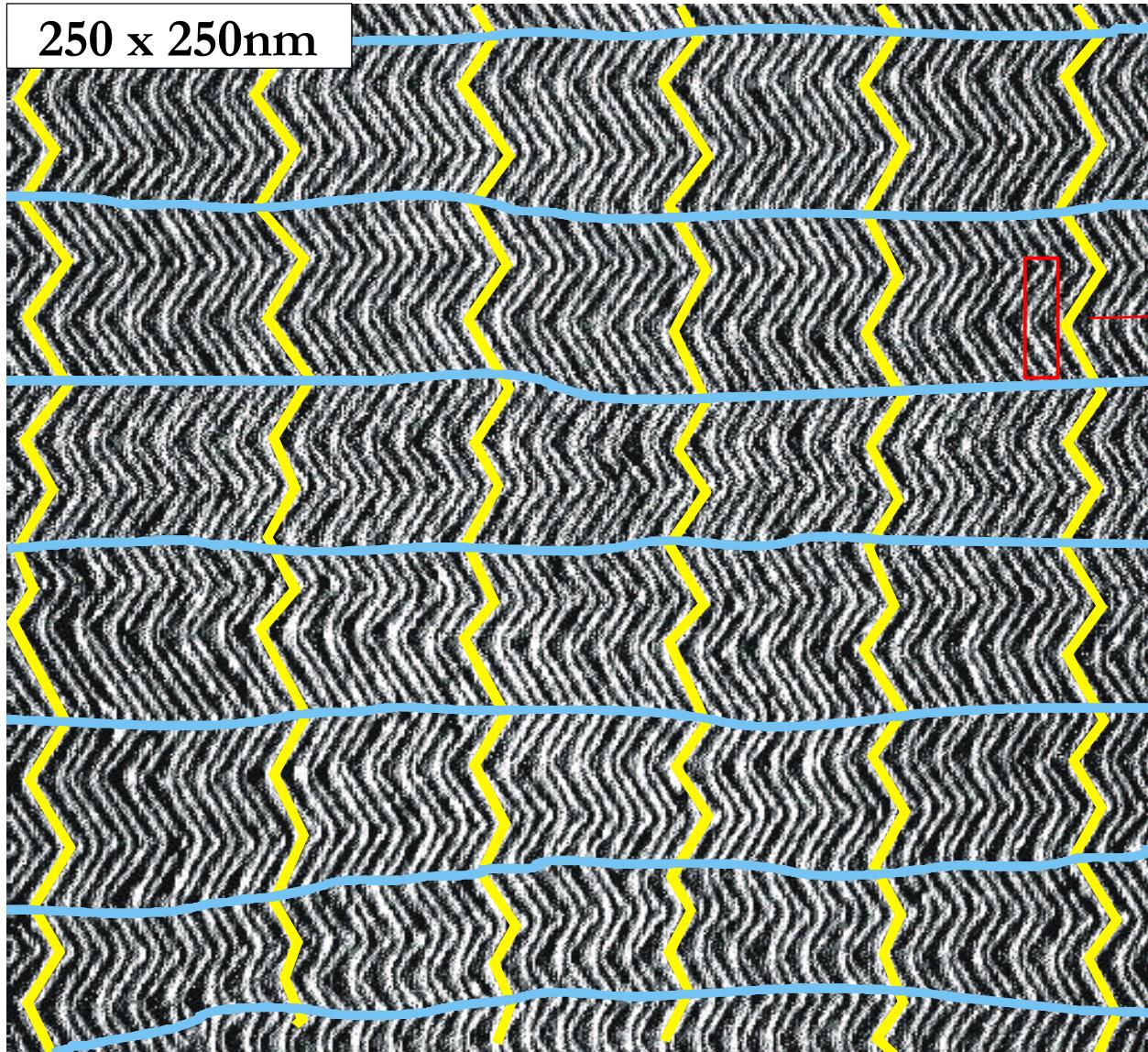
Atoms of the topmost layer

● Site A

 Site C

● Saddle position

(smaller diameter for clarity only)



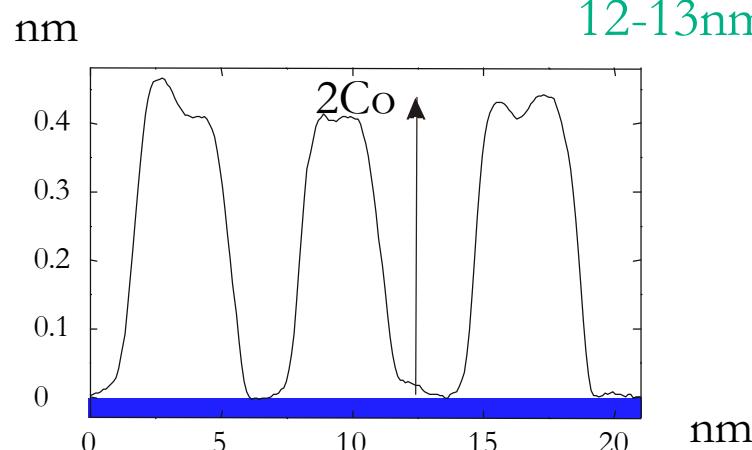
Corrugation $\sim 0.2 \text{ \AA}$
Unit cell size :
 $\sim 7.5 \times 25 \text{ nm}$

Isotropic surface relaxation

J. V. Barth et al., Phys. Rev. B 42 (15), 9307 (1990)
A.R. Sandy et al., Phys. Rev. B 43 (6), 4667 (1991)

- Co, Ni, Fe :
Nucleation at the
elbows of the chevrons

7.5nm
(0.20AL Co@300K)

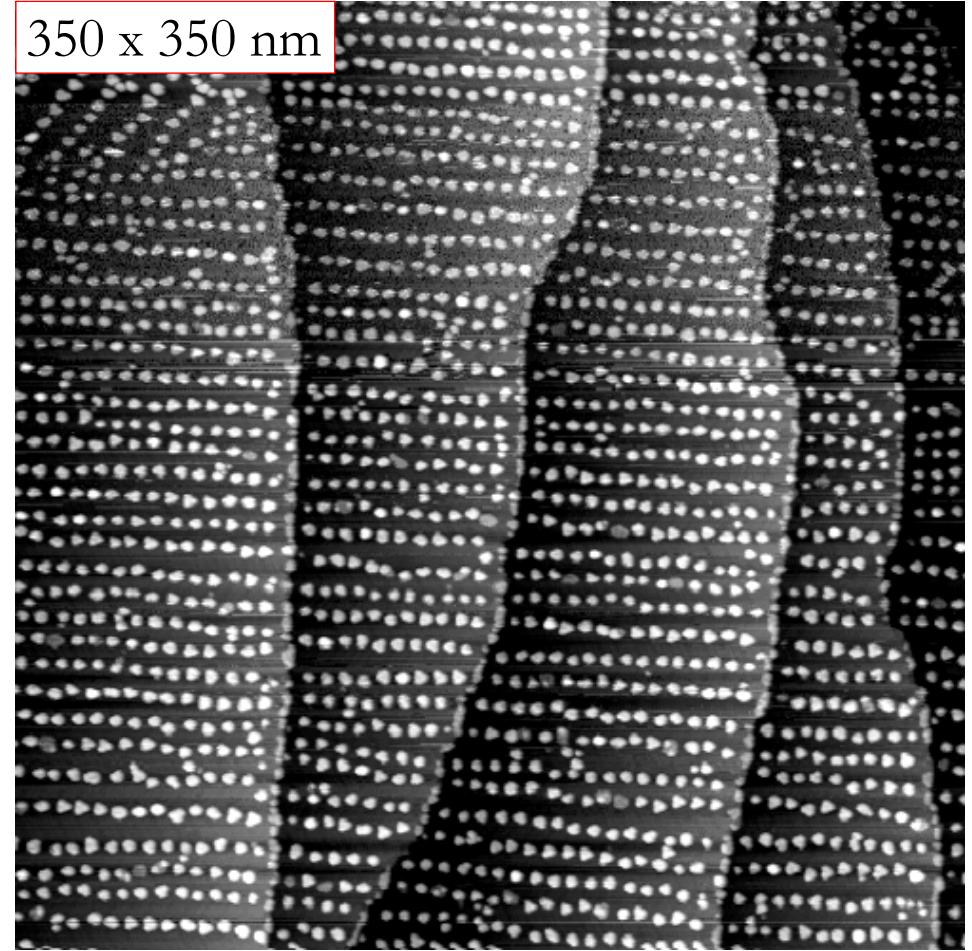


Fe, Ni : 1 AL-high dots

D.D. Chambliss et al., PRL **66**, 1721 (1991)

B.Voigtlander et al., PRB **44**, 10354 (1991)

350 x 350 nm

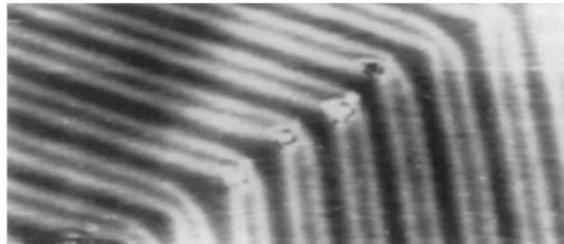


- Medium-ranged organization
- Steps do not necessarily disturb the order
[see also:
V.Repin, Europhys. Lett., **47** (4), 435 (1999)]

Fe, Co, Ni (etc.) nucleation: atomic place exchange mechanism with Au atoms

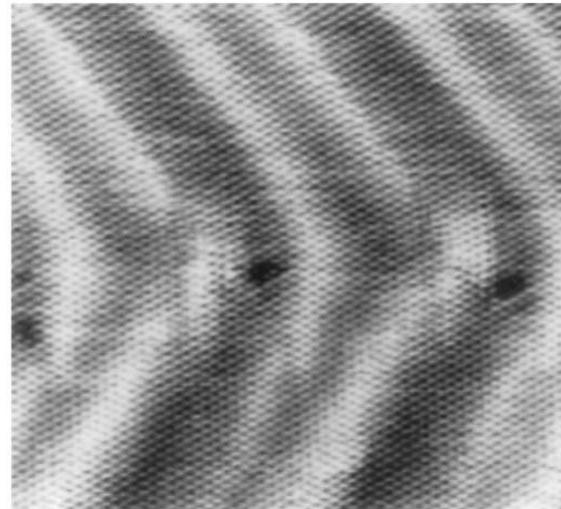
Example: 0.002ML Ni@300K

a)



Element	Surface free energy (eV)	Heat of sublimation (eV)
Ag	0.50	2.95
Al	0.56	3.39
Cu	0.69	3.51
Au	0.72	3.79
Ni	0.90	4.45
Co	0.94	4.40
Fe	0.96	4.32

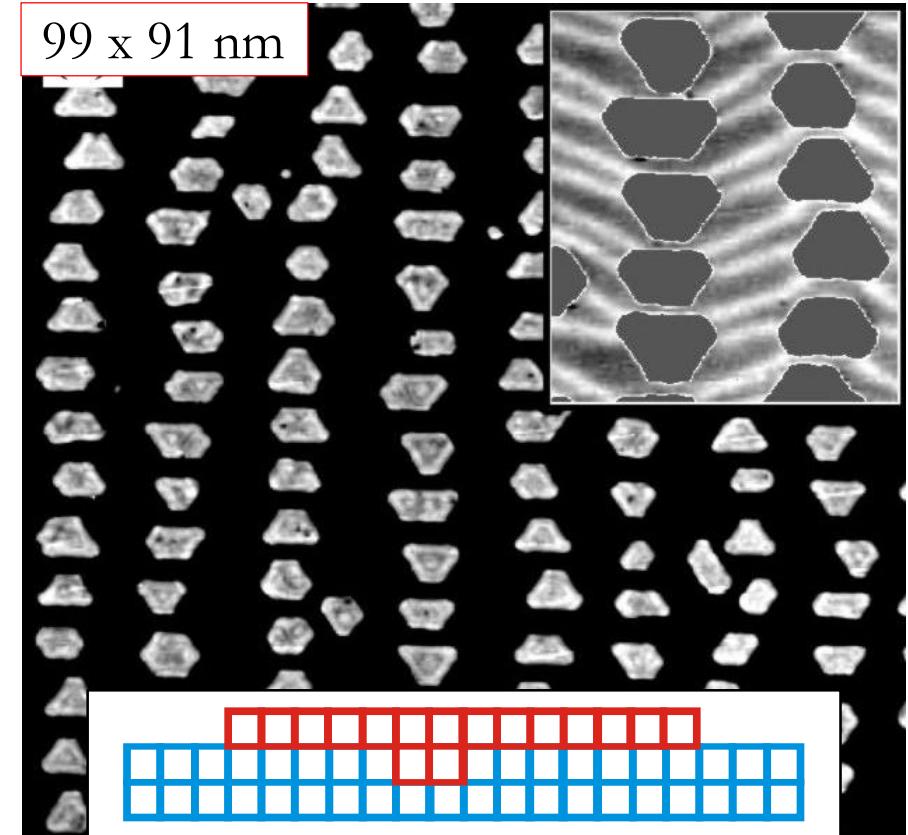
b)



J.A.Meyer et al., Surf.Sci.**365**, L647 (1996)

0.25ML Ni@300K : 1ML-high dots

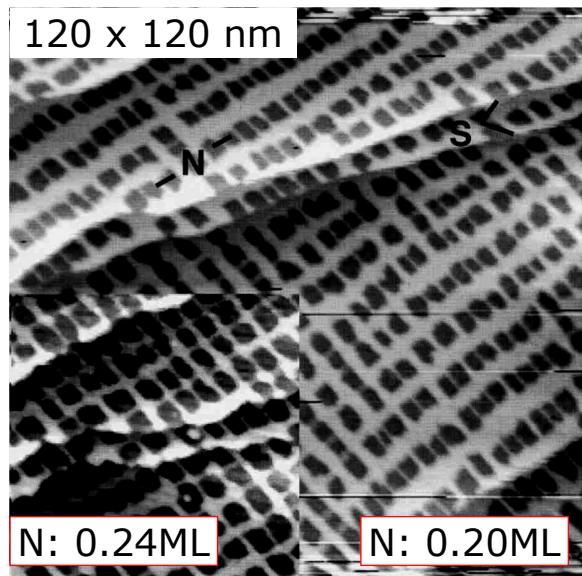
99 x 91 nm



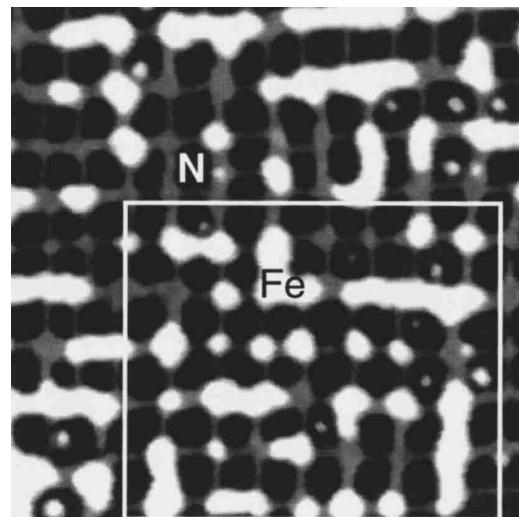
W.G.Cullen et al., Surf.Sci.**420**, 53 (1999)

Leading parameter : deposit has a higher surface energy.
(and Au atoms stress near chevrons)

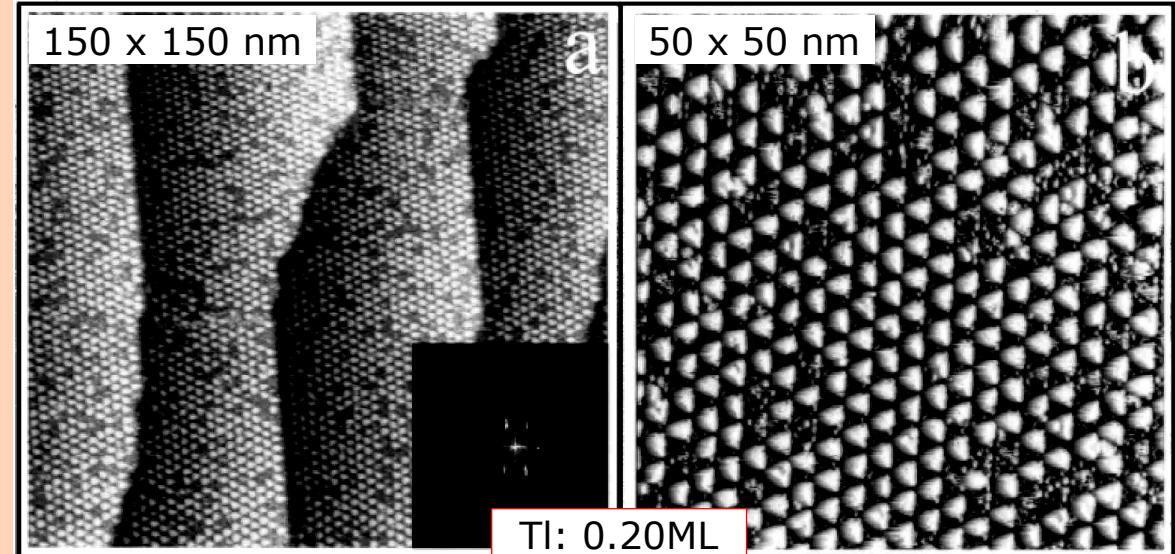
➤ Self-organized adsorption: N on Cu(100)



T.M.Parker, Phys.Rev.B**56**, 6458(1997)

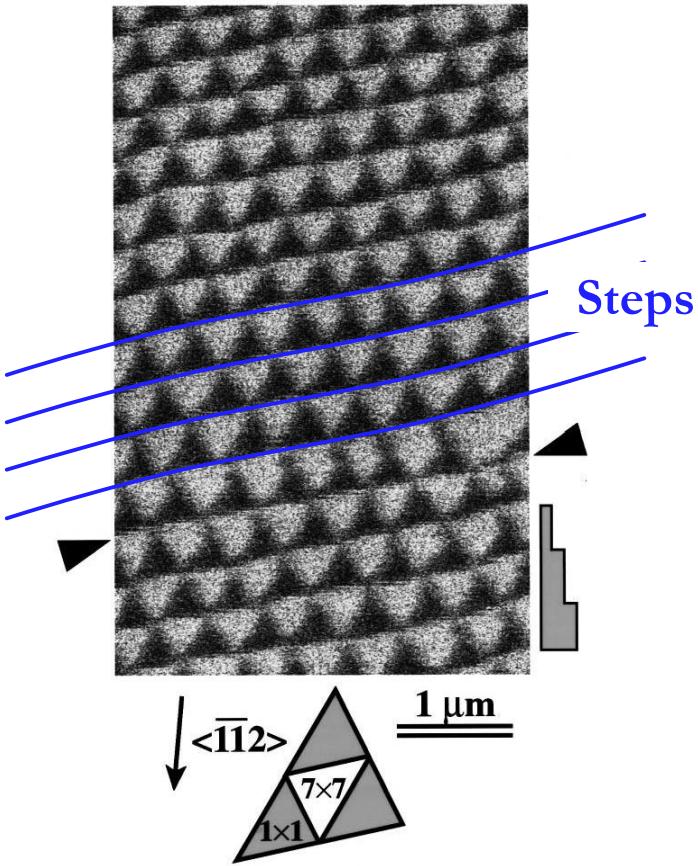


➤ Self-organized growth on **reconstructions**
Tl on Si(111) 7x7



L.Vitali, Phys.Rev.Lett.**83**(2), 316 (1999)

- Superstructure of reconstructions: 7x7 and 1x1 triangles on Si(111), misoriented along $<1\bar{1}2>$



H.Hibino, Phys.Rev.B58(12), R7500 (1998)

➤ Co on vicinal Au(111)

Steps and reconstructions

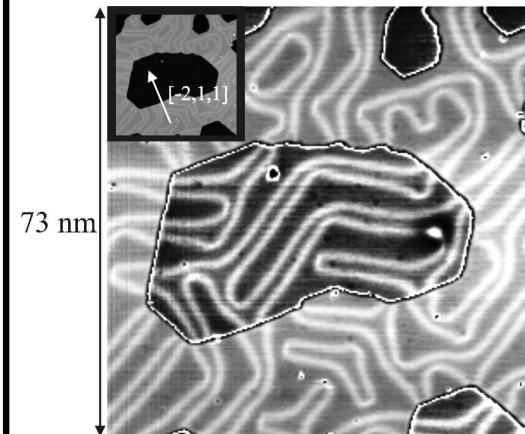


FIG. 4. STM image of a few vacancies islands. T=300 K. Inset, the raw STM image. The same image is shown where the conjugation due to the terrace levels has been subtracted in order to enhance the reconstruction lines.

Reconstructions lie
perpendicular to steps

V.Repin, Europhys. Lett., **47** (4), 435 (1999)
V.Repin, ACSIN5 proceedings

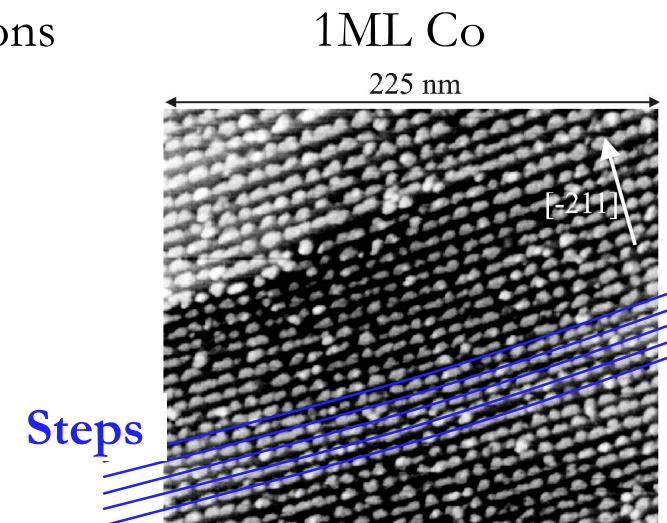
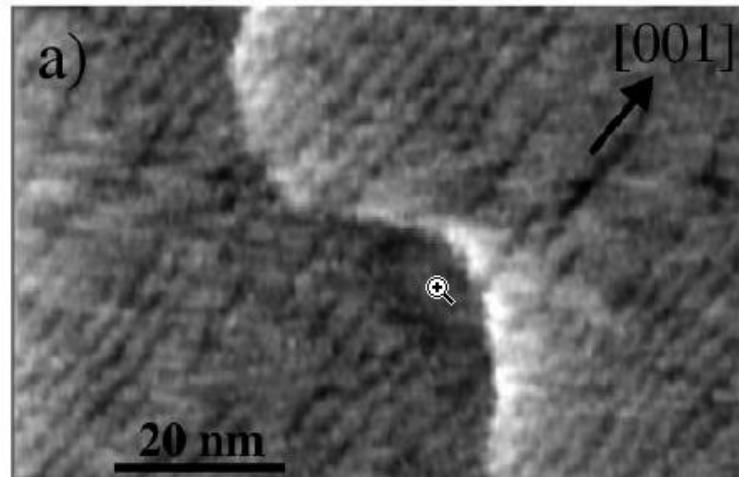


FIG. 6. Rectangular lattice (7 nm x 8 nm) of cobalt clusters on a vicinal surface misoriented from 1.7° with respect to Au(111) towards the [211] azimuth. Cobalt coverage is 1 ML. Arrow indicates the descending steps direction.

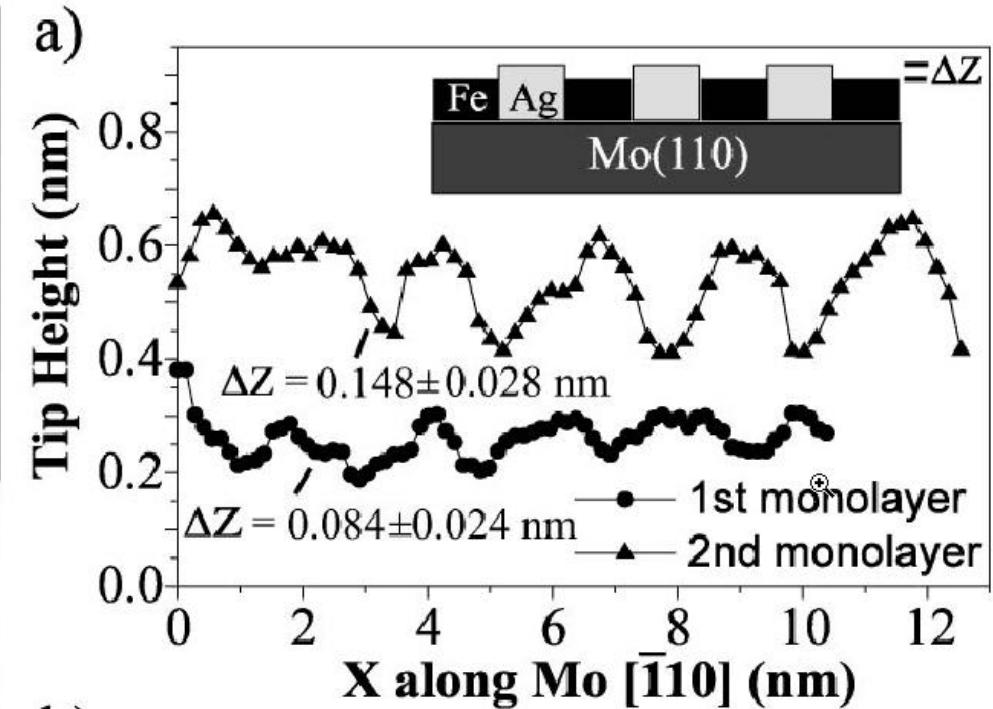
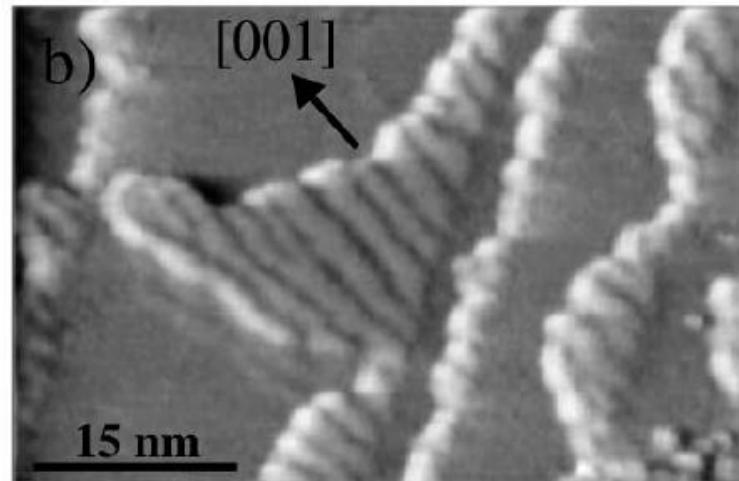
Nucleation both at
steps and at reconstructions

Lateral modulation in ultrathin films

FeAg/Mo(110)
1AL



CoAg/Mo(110)
0.3AL



E. D. Tober et al., PRL81, 1897 (1998)



Stéphane ANDRIEU: possible link with Fe/V(110) ?



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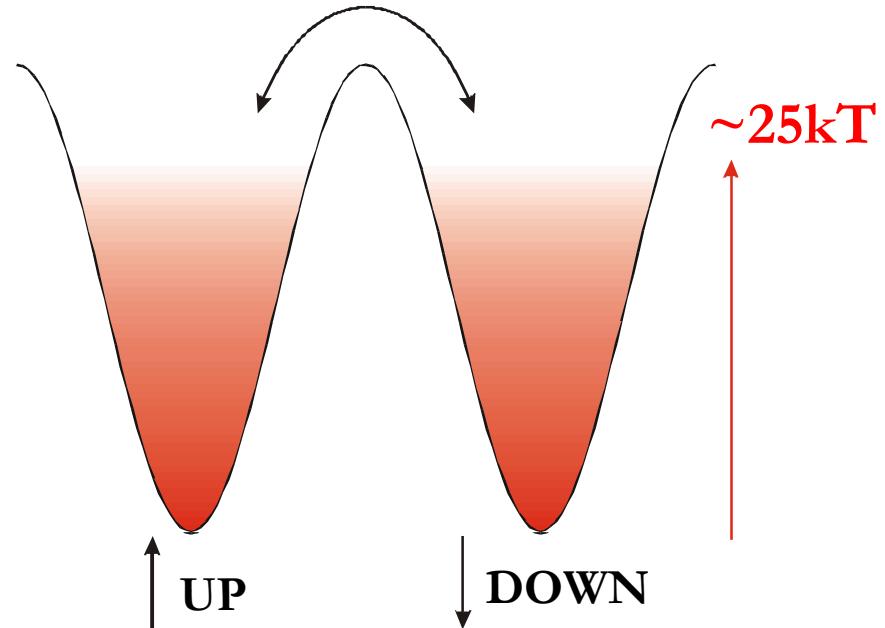
- Self-organization generally from substrate, not from deposit !
- Relies on surface science fundamental investigations

- combine
- Surface reconstructions
 - Overlayer array of dislocations
 - Adsorbates patterns
 - 1D or 2D array of steps
 - Steps (or bonding ?) and reconstructions
- Better size control

- Good pattern does not necessarily imply good overgrowth

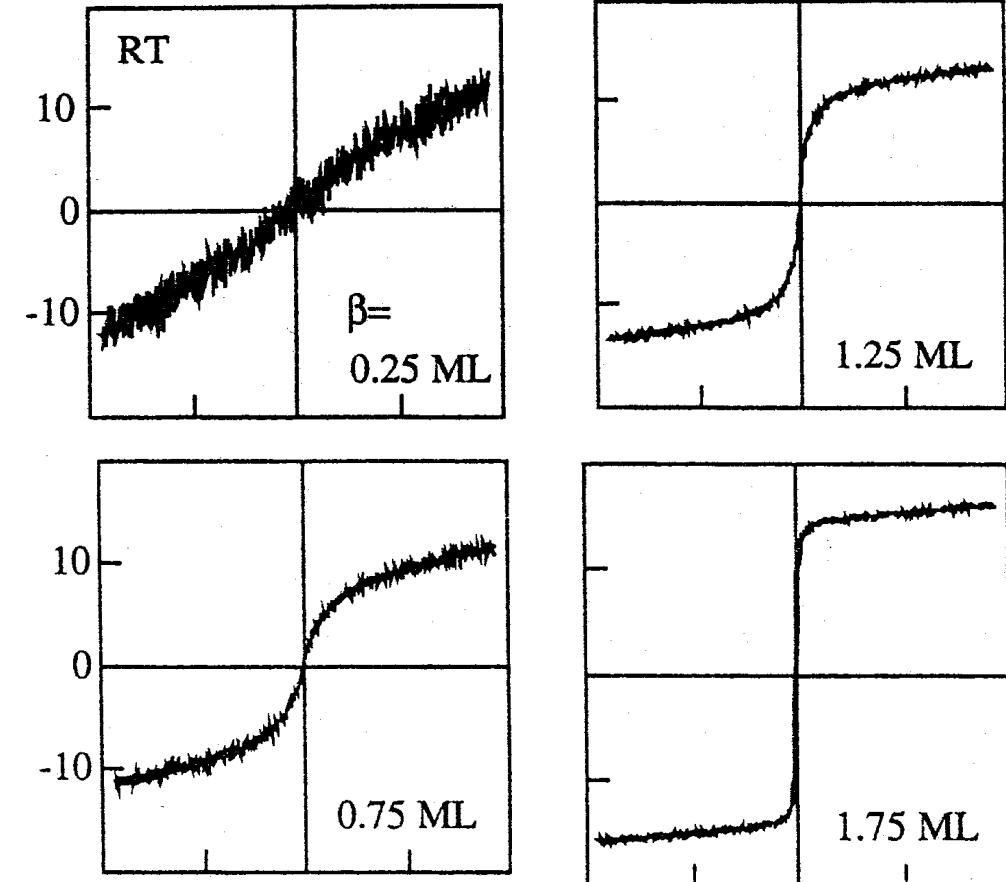


Anisotropy barrier ~KV



Blocking temperature $T_b \sim 20K$
H.Dürr et al., PRB**59**, R701 (1999)

Example: Co/Au



H.Takeshita et al., JMMM**165**, 38 (1997)



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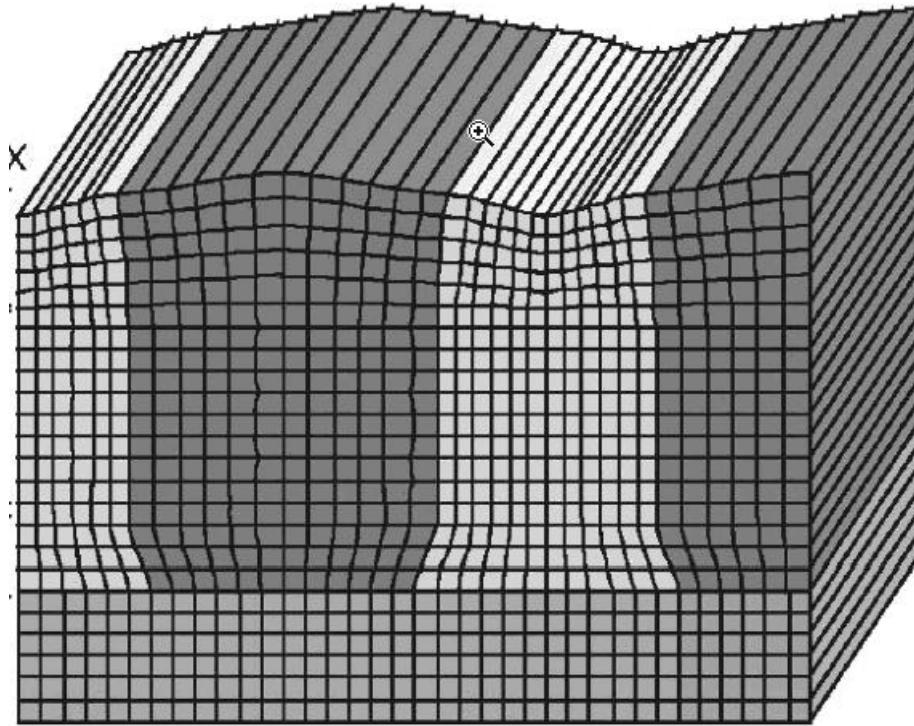
References



Principle

Strain release

Here: accumulation during growth

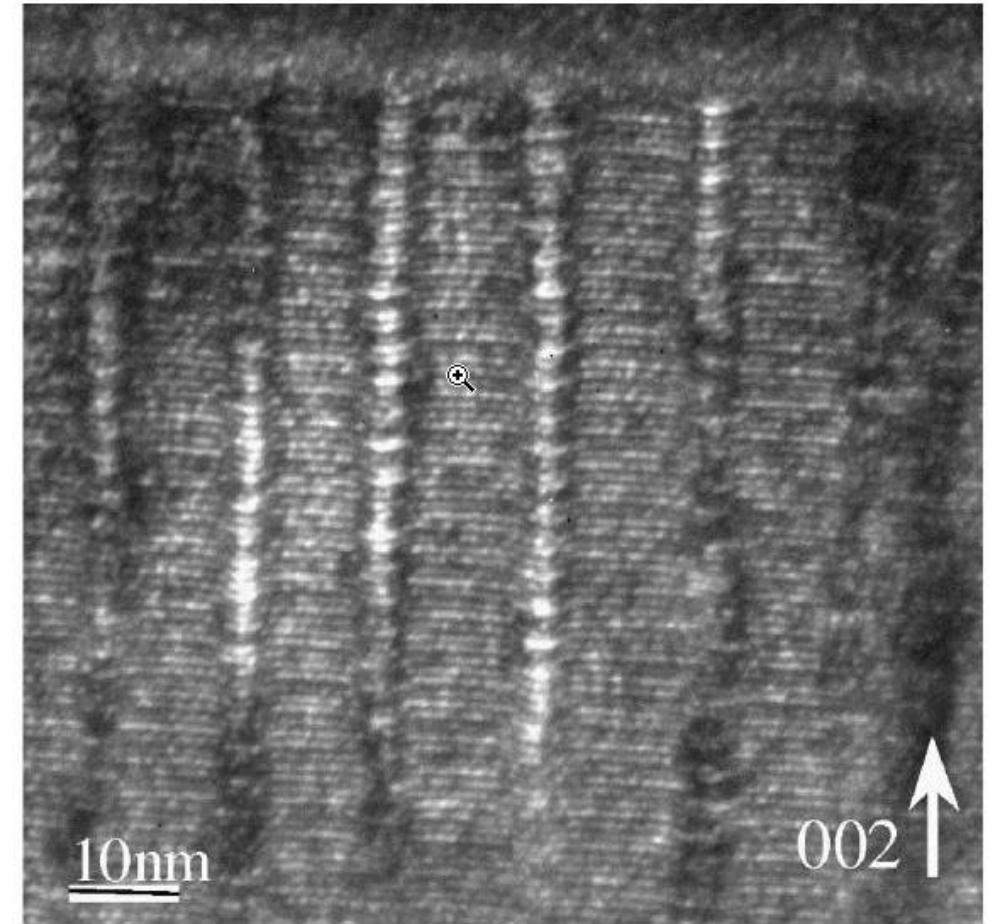


R. D. Tweten et al, PRB60, 13619 (1999)

[Cf Grinfeld instability: M. A. Grinfeld, Dok. Akad. Nauk SSSR 290, 1358 (1986)]

Experiments

InAs/AlAs short-period multilayers



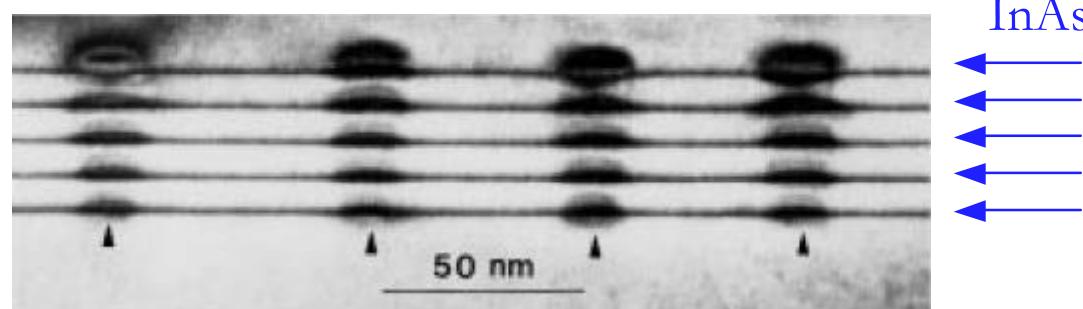
R. D. Tweten et al, PRB60, 13619 (1999)



Laboratoire Louis Néel, Grenoble, France.

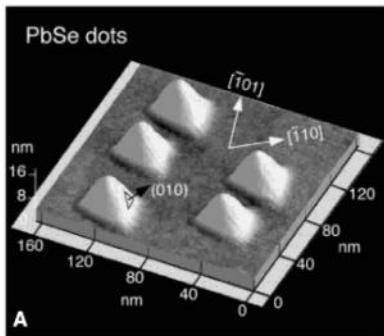
InAs / GaAs(100)

- Strain field in spacer layer :
 - ↳ vertical stacking of dots

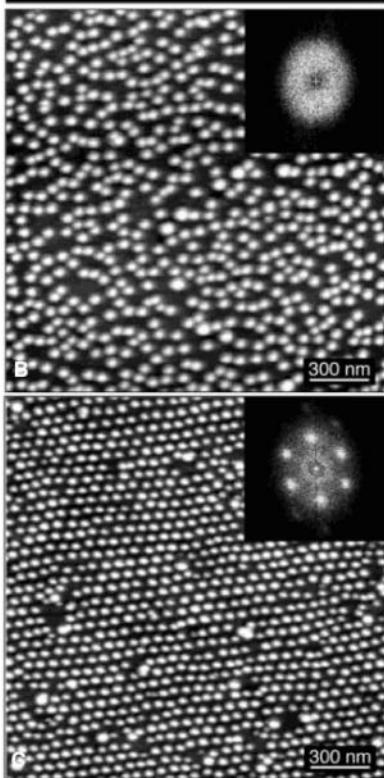


Q.Xie, Phys.Rev.Lett.75(13), 2542 (1995)

➤ From 2D assembly to
3D- organization



Zoom :
facetted dots



Single layer :
Self-assembly,
no organization.

Multilayers :
improvement of
the organization.

(After 60 layers)



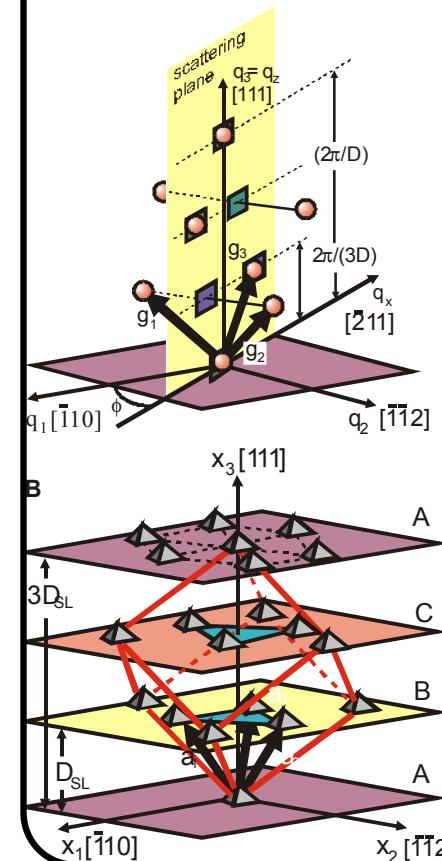
G.Springholz, Science 282, 734 (1998)

Laboratoire Louis Néel, Grenoble, France.

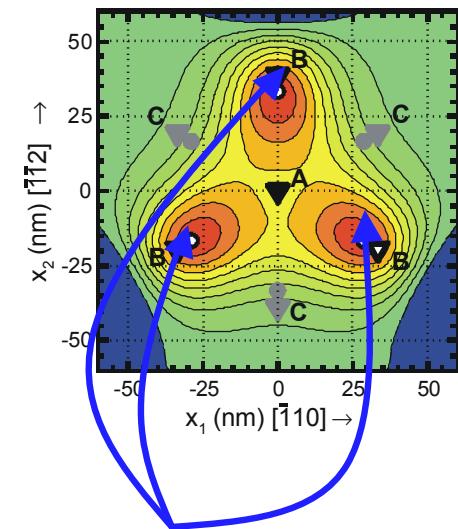
PbSe / PbTe(111)

➤ Anisotropic elastic media
↳ f.c.c. superstacking, not vertical.

X-Ray diffraction



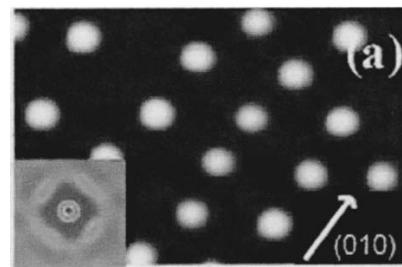
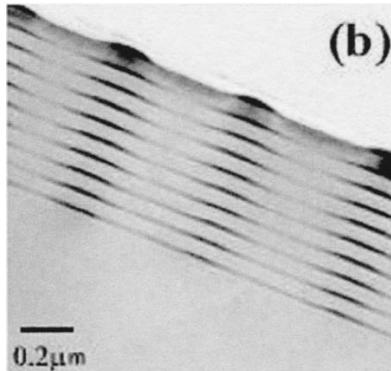
Anisotropic in-plane
distribution of
elastic energy density



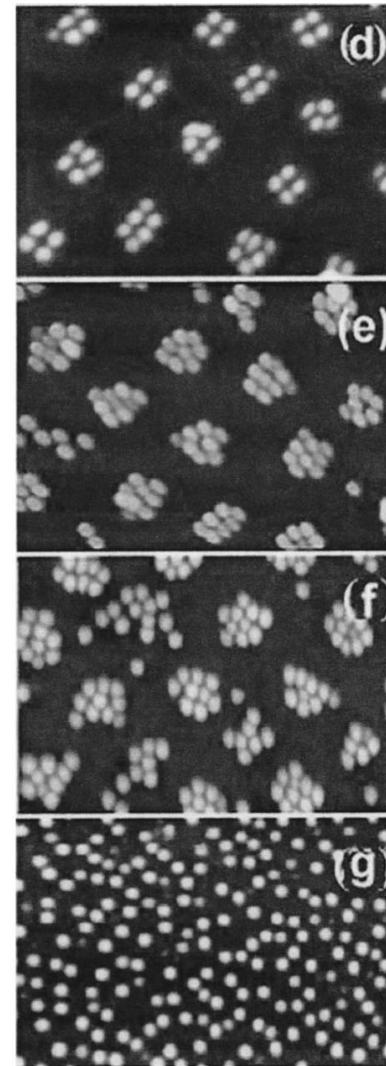
Misfit reduced by 2%
↳ preferential nucleation

Step 1 multilayers for organization

Ge islands/Si(001)



Step 2 use as a template



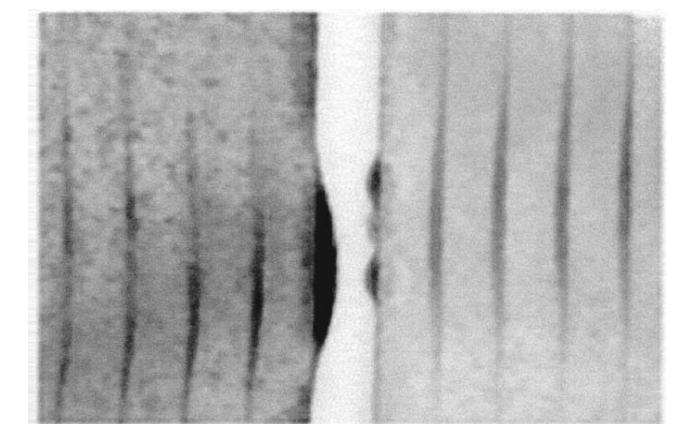
35nm

45nm

65nm

200nm

HREM view



Template

Overgrowth

G. Capellini et al., APL82, 1772 (2001)



Laboratoire Louis Néel, Grenoble, France.

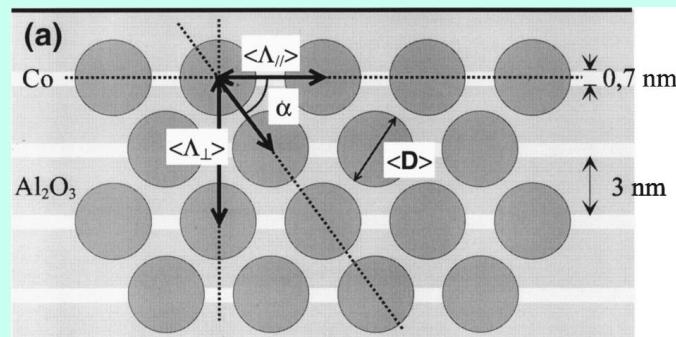
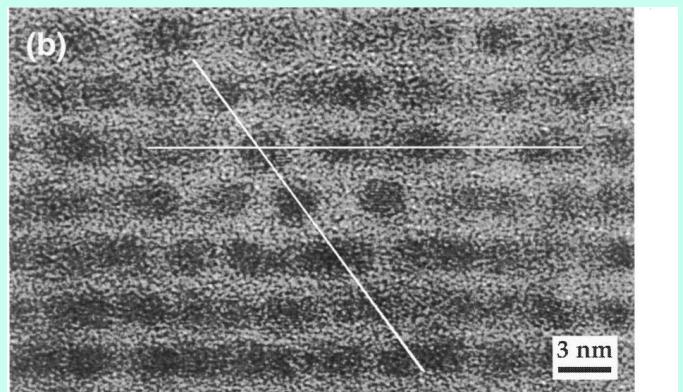
Olivier Fruchart - 2/09/2003 - p.28

Co/Al₂O₃ granular system (sputtering)

(Co: 0.7 nm/Al₂O₃: 3 nm)₁₄

REAL SPACE

TEM cross-section (Sequential sputtering)



➤ FCC vertical stacking (not epitaxial !)

D. Babonneau, Appl. Phys. Lett. 76, 2892 (2000)

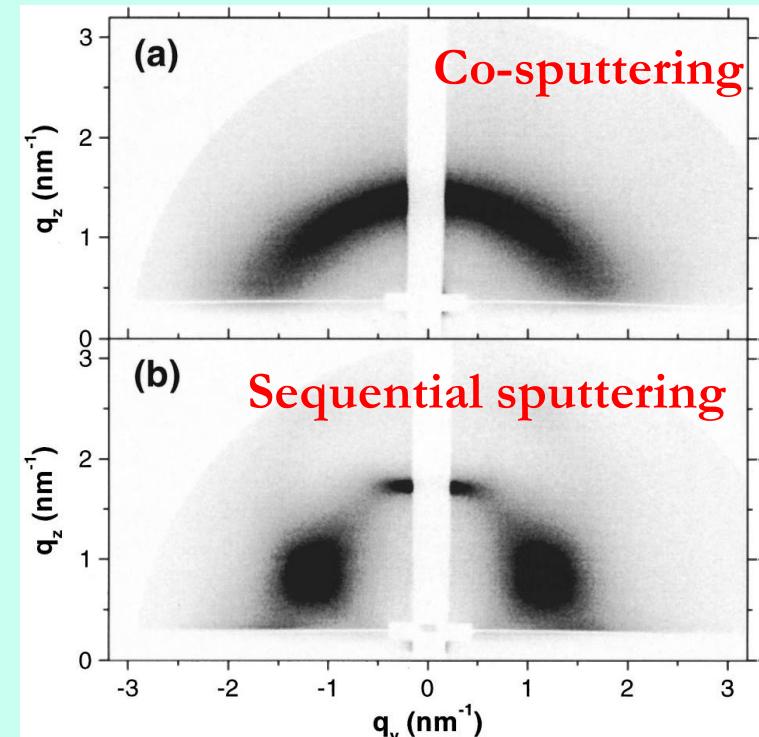


Laboratoire Louis Néel, Grenoble, France.

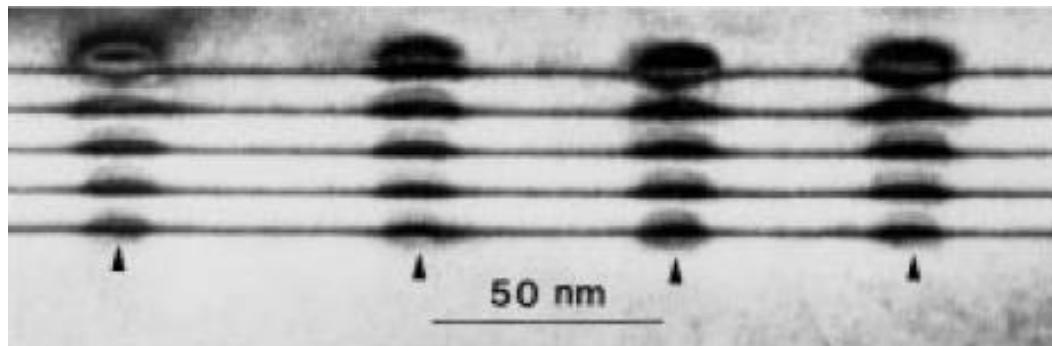
RECIPROCAL SPACE

GISAXS:

Grazing Incidence Small Angle X-Ray Scattering

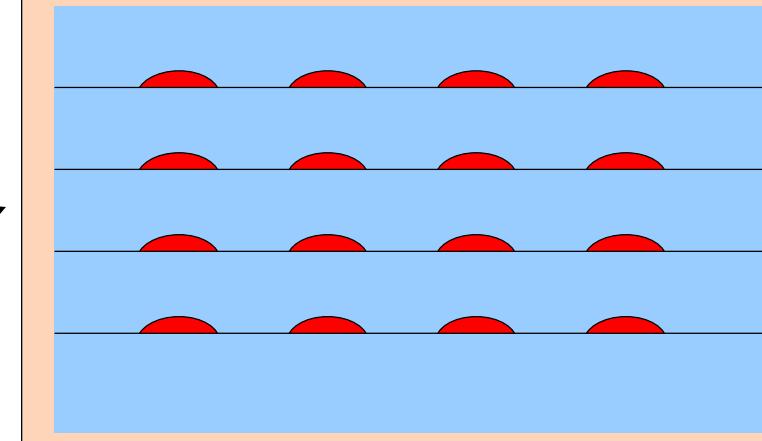


- Vertical 3D self-organization of
 $\text{In}_x\text{Ga}_{1-x}\text{As}/\text{GaAs}$:



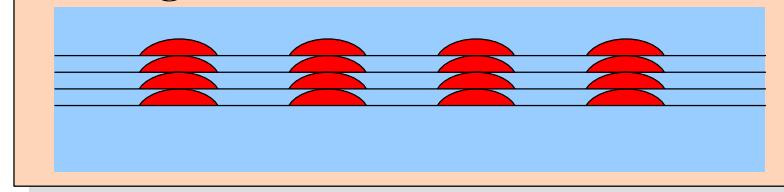
Q.Xie et al., Phys.Rev.Lett.75(13), 2542 (1995)

Assembly of isolated dots



Thining the spacer layer

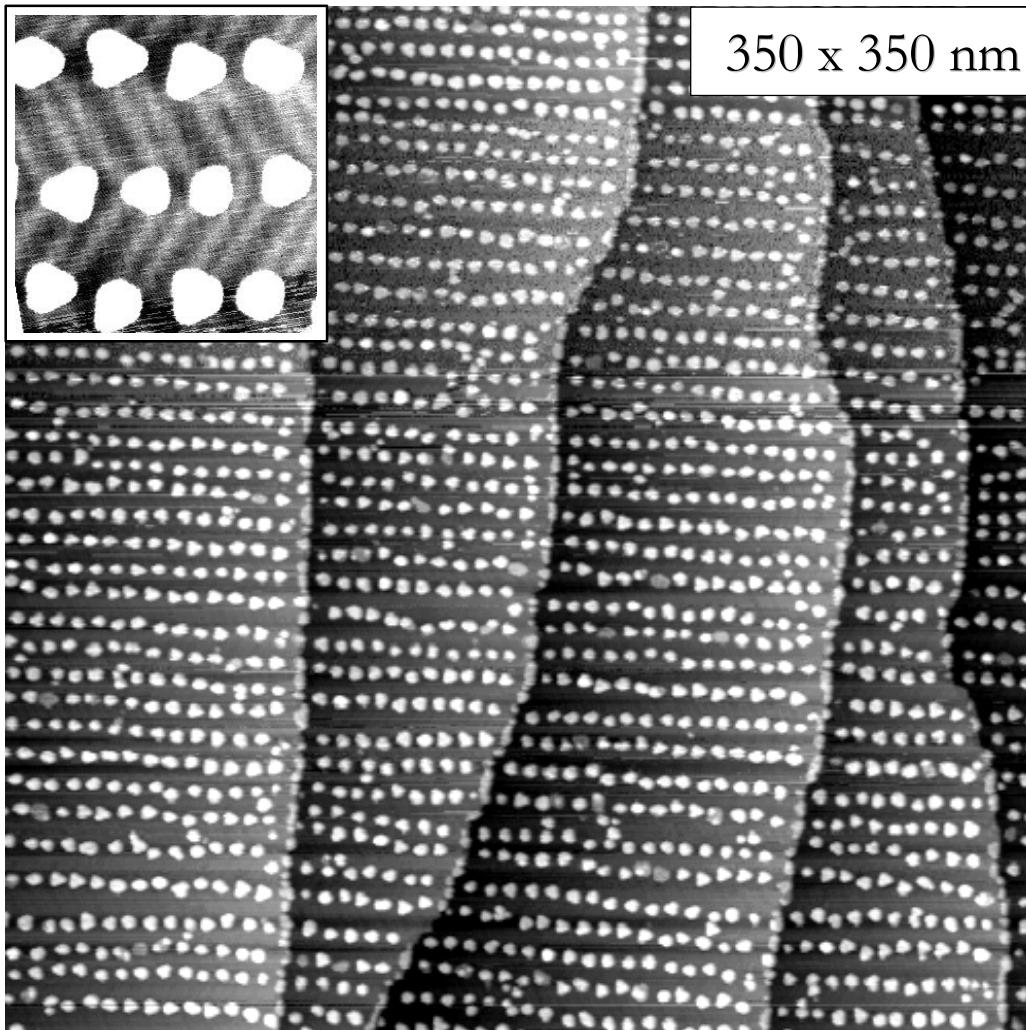
Strong interaction between dots?



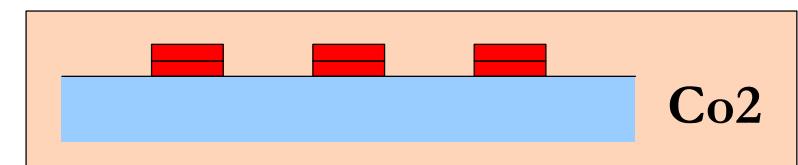
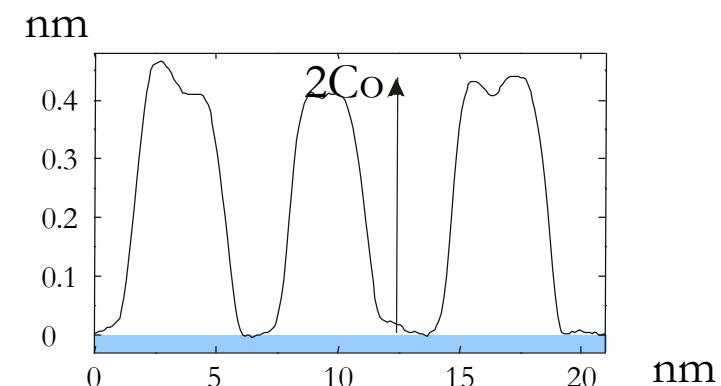
→ superparamagnetism overcome ?

→ Enhanced magnetic signal

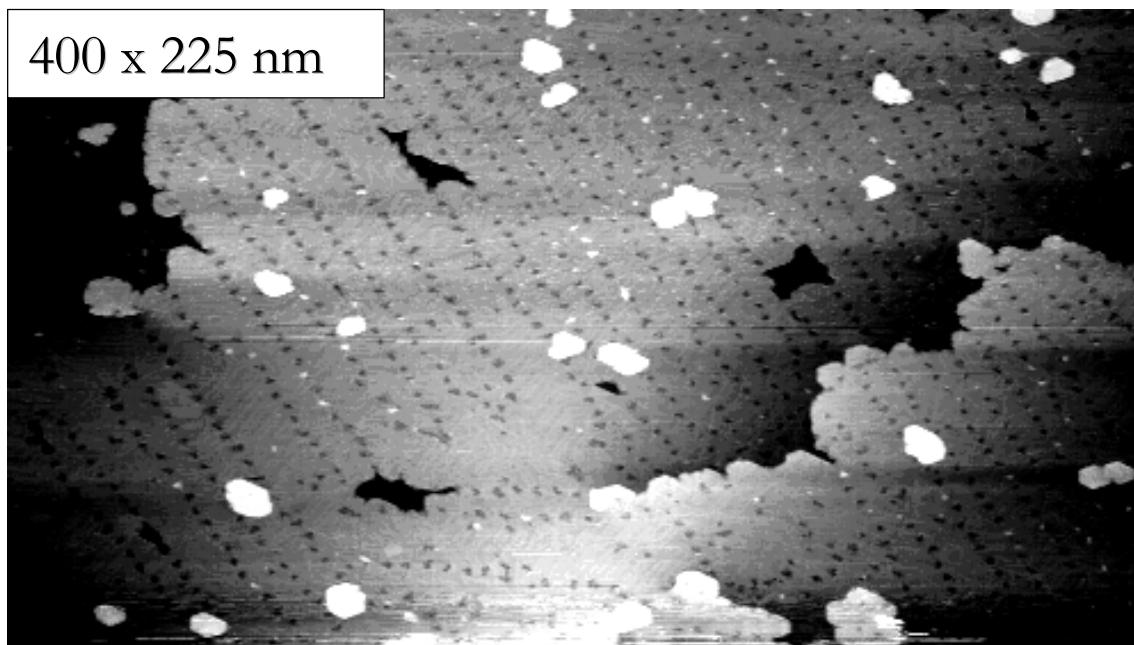
➤ Step 1 : 0.2ML Co @300K



Typical cross-section :



➤ Step 2: 3.8ML Au @375 ↗ 410K

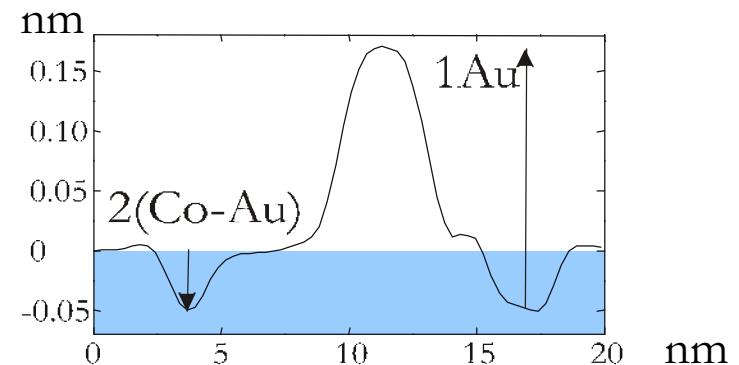


See also : Wollschläger *et al.*, Surf.Sci. **277**, 1 (1992)

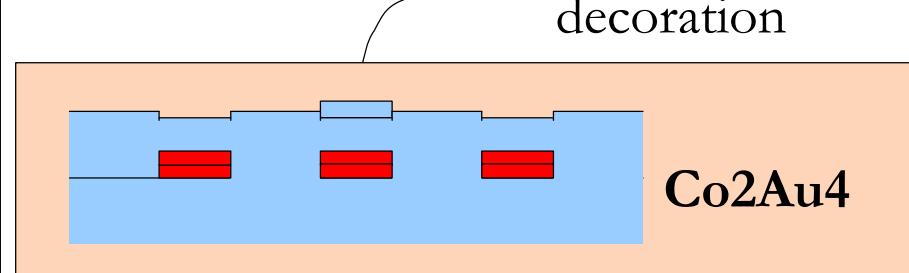
1ML Co hcp \approx 0.205nm
1ML Au fcc \approx 0.235nm

} Array of hollows

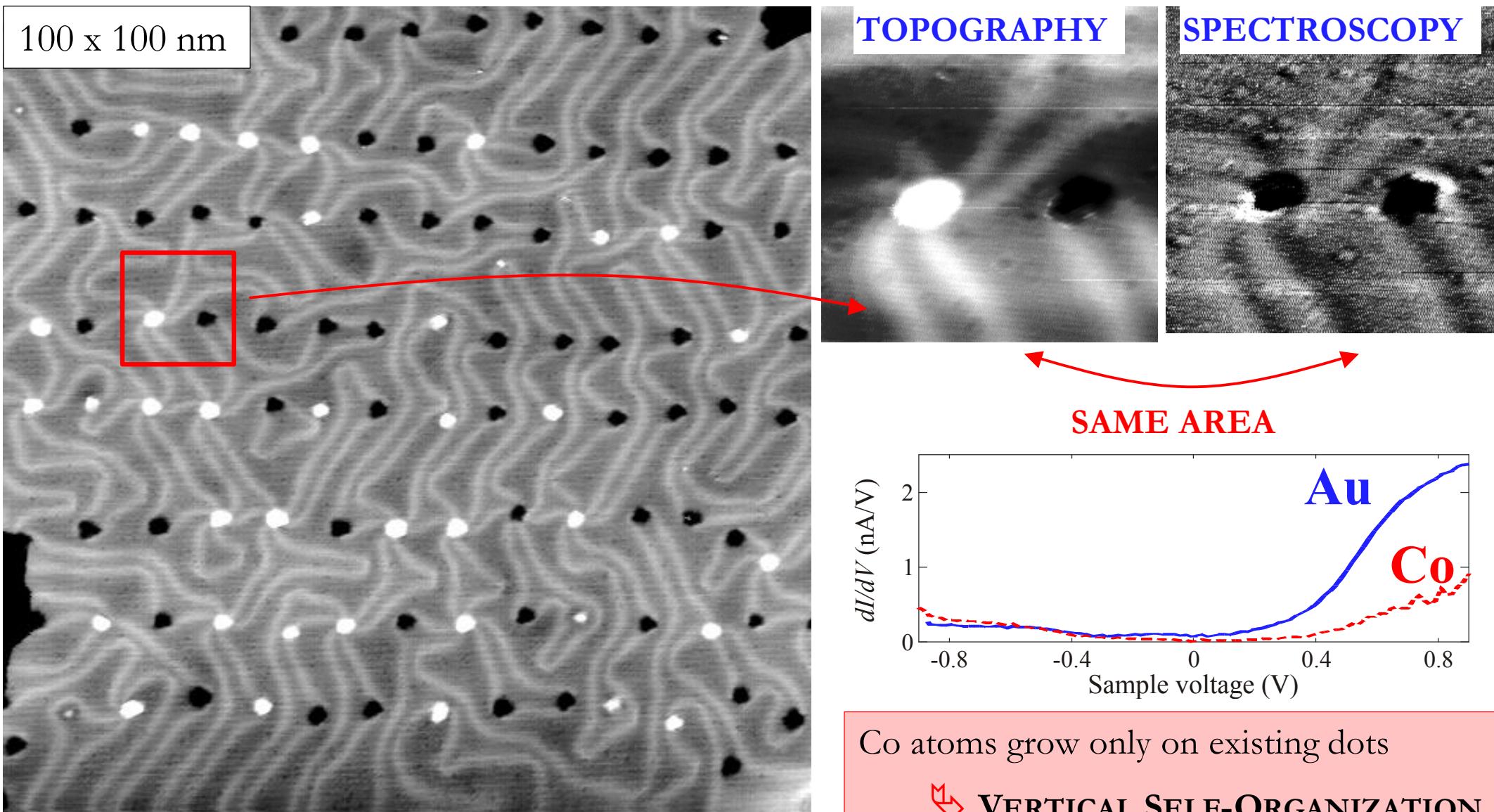
Typical cross-section :



1ML Au
decoration



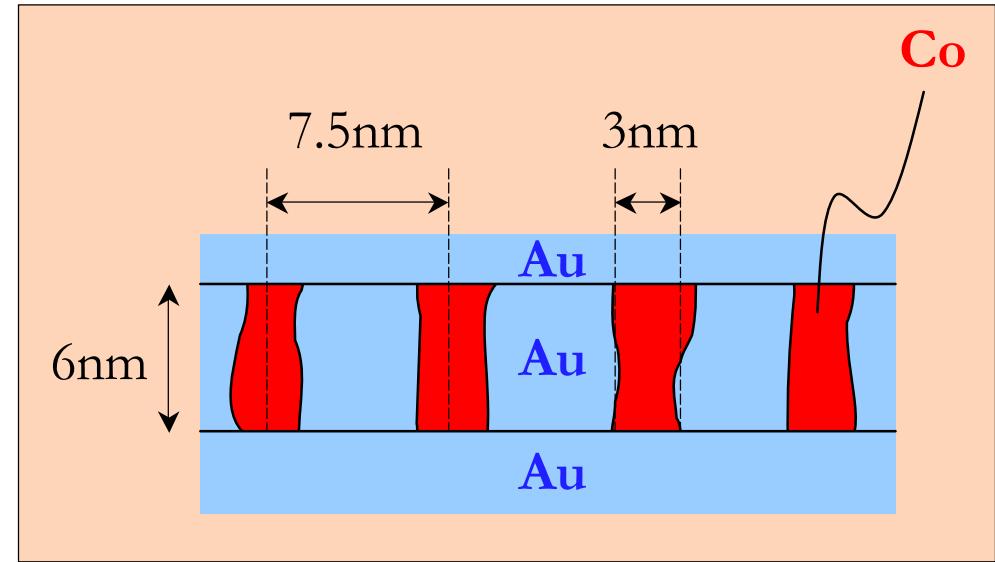
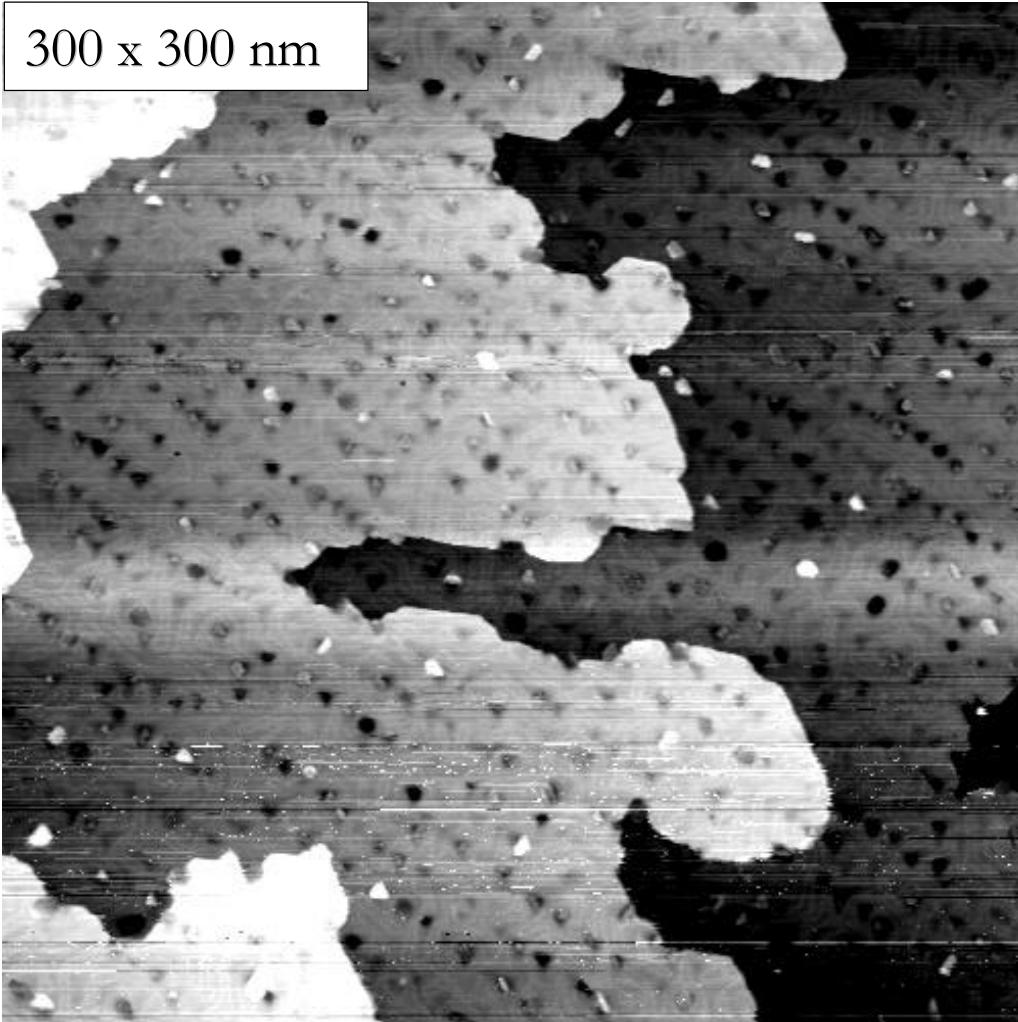
- Surface smoothing
- Unaffected Co dots



Laboratoire Louis Néel, Grenoble, France.

Olivier Fruchart - 2/09/2003 - p.35

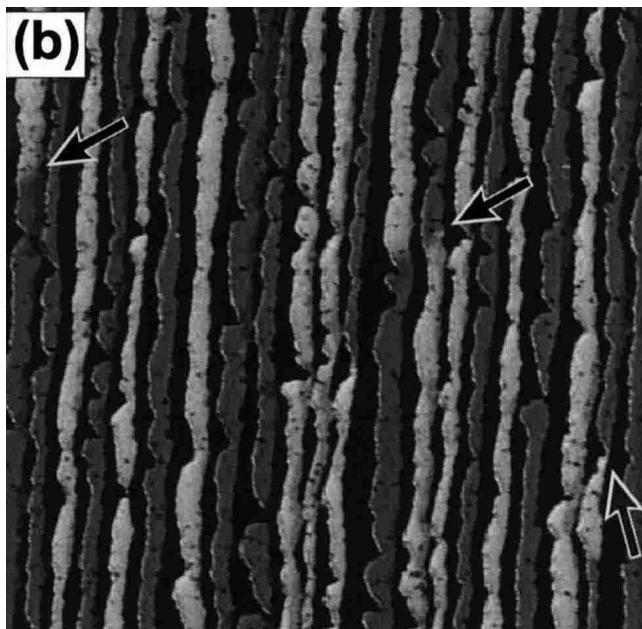
300 x 300 nm



- Self-organization nearly undisturbed
- Pillars with 2:1 vertical aspect ratio
- Unclear to this point :
 - Exchange mechanism
 - Limitating factors ?
 - Composition, microstructure ?

ATOMIC LAYER RANGE : WETTING

↳ nanometer-world / surface physics



1.5AL on
vicinal
Fe/W(110)

M. Bode et al, J. Electr. Spectr. Rel.
Phenom. 114– 116, 1055 (2001)

THICK DEPOSITS : NO WETTING

↳ micrometer-world / materials physics

Fe/Mo(110)

(Pulsed Laser Deposition)

AFM, ~1 μm

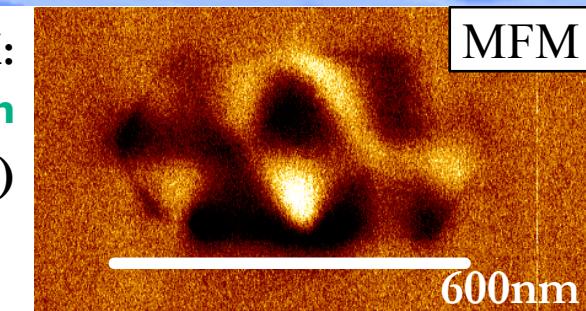
MFM:

Y. Samson
(CEA/France)

MFM

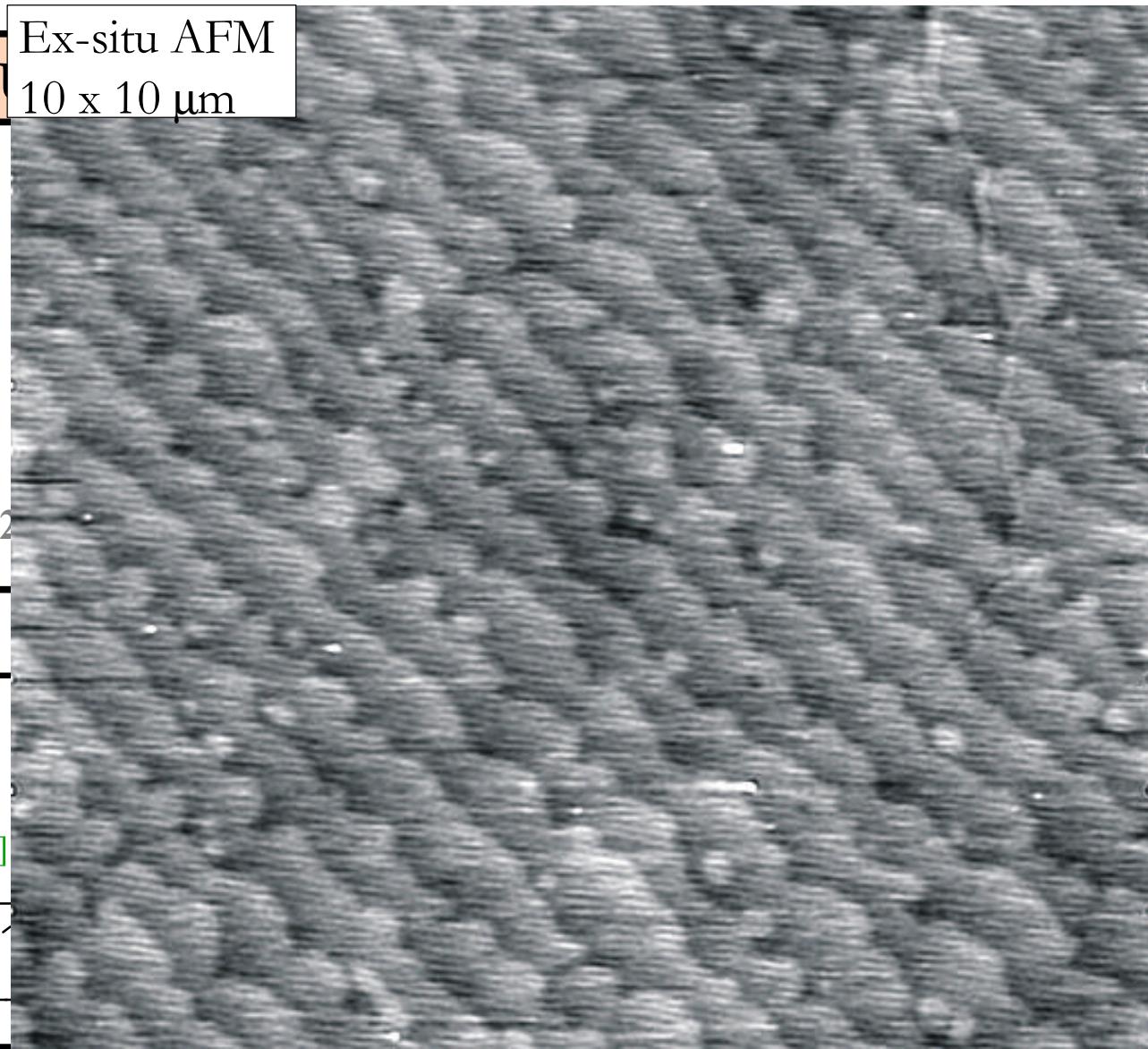
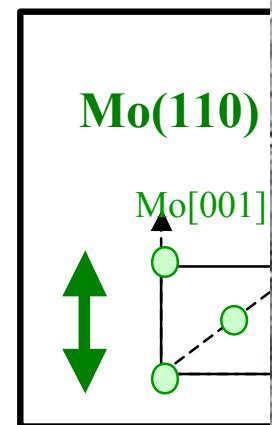
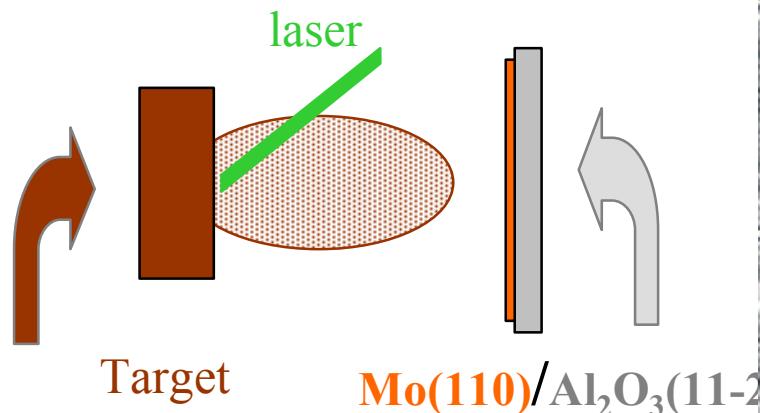
P.-O.Jubert et al., JMMM 226, 1842 (2002)

P.-O.Jubert et al., PRB64, 115419 (2002)



↳ Is there an intermediate world ?

PULSED LASER DEPOSITION,

Ex-situ AFM
10 x 10 μm 

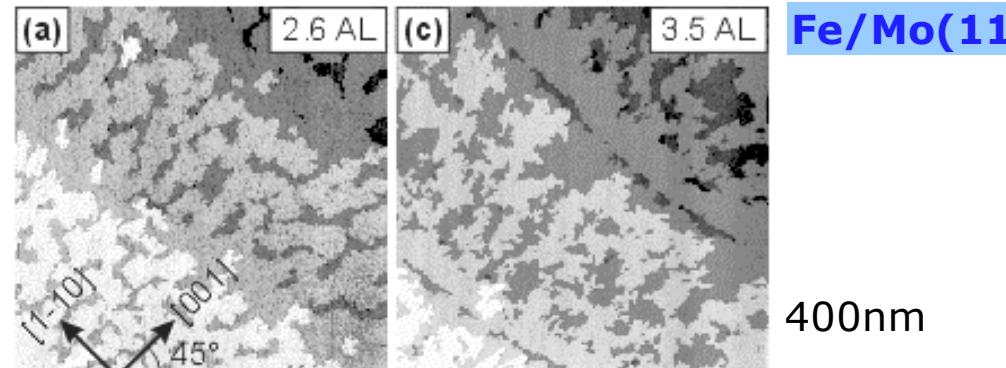
Buffer layer growth : O. Fruchart, S. Jaren, J. Rothman, Appl. Surf. Sci. 135, 218 (1998)



Laboratoire Louis Néel, Grenoble, France.

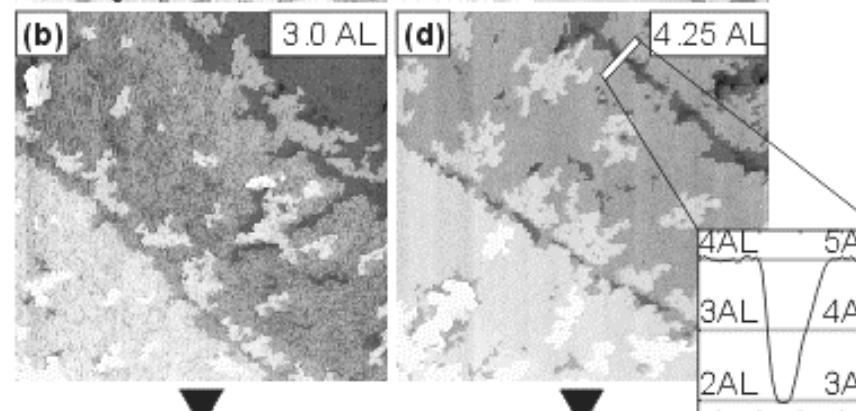
Olivier Fruchart - 2/09/2003 - p.40

150°C deposition



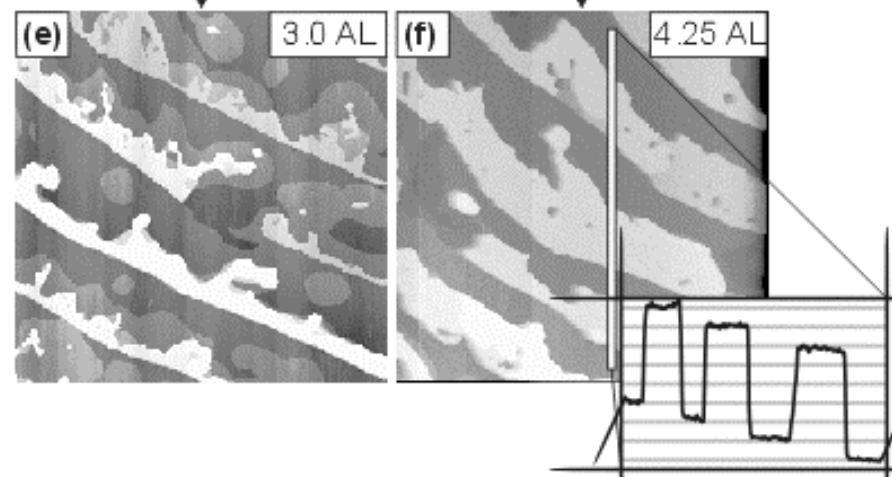
Fe/Mo(110)

400nm



400nm

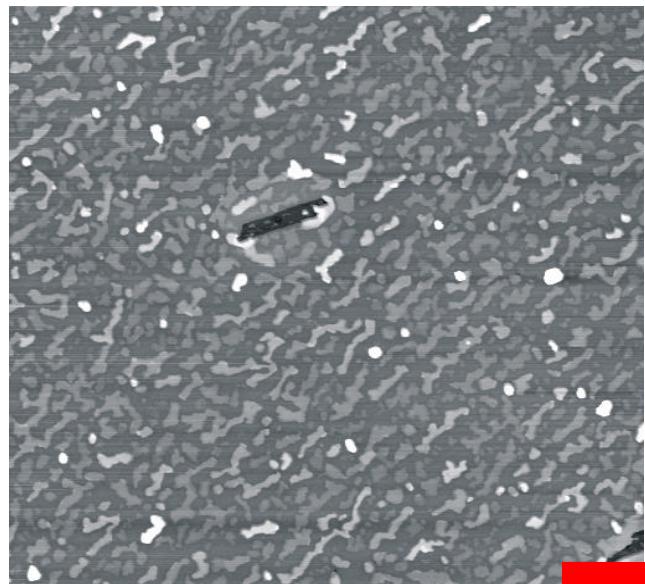
450°C annealing



Sapphire\Mo(8nm)\interface\Fe(150°C, 450°C annealing)

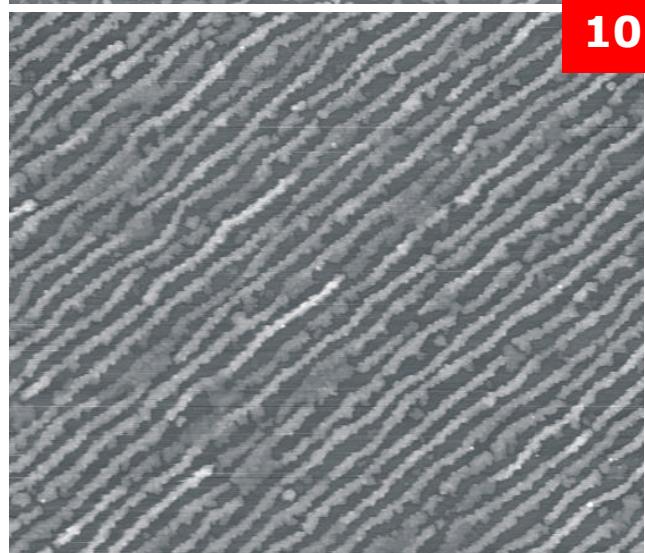
W(<1nm)

1nm



Mo(raw)

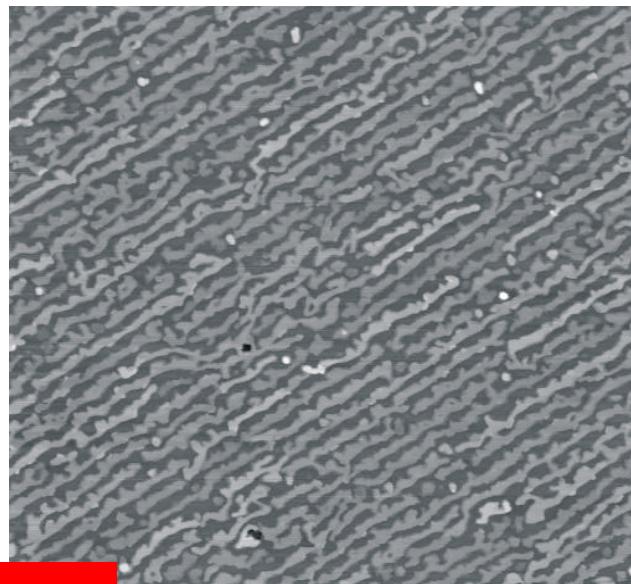
10 mm



Chemical
interface

Laboratoire Louis Néel, Grenoble, France.

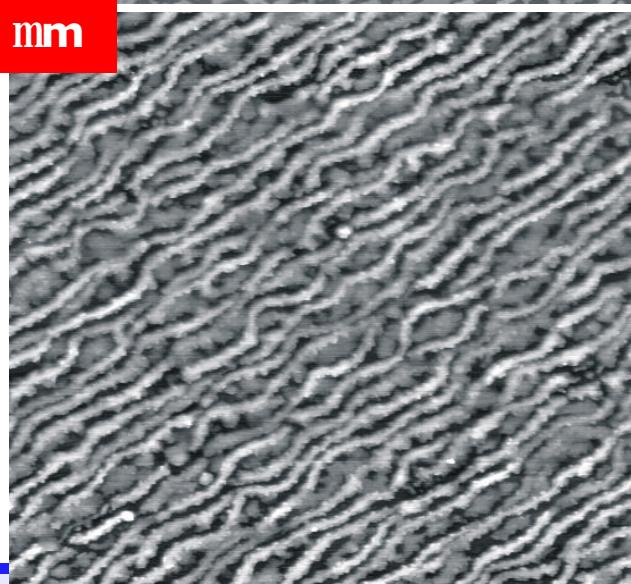
2.5nm



Average thickness

Height : 5nm

Height : bimodal
1.5/4nm



(1. Introduction)

2. Self-assembled epitaxial growth

3. Self-organized epitaxial growth

4. 3D self-organization via multilayer stacking



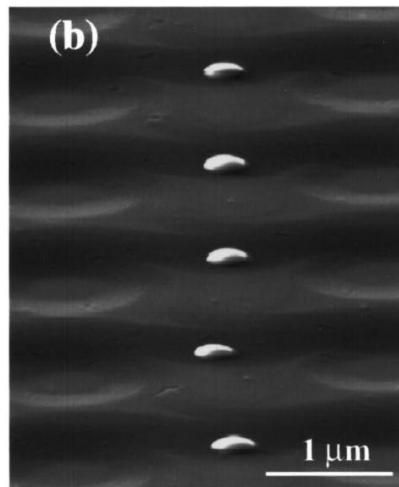
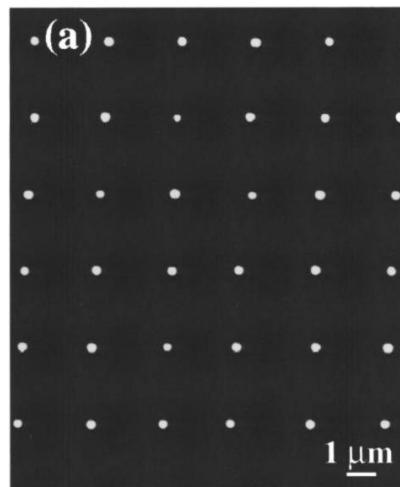
5. Perspectives of self-organization

6. X-ray investigation of SO systems

References

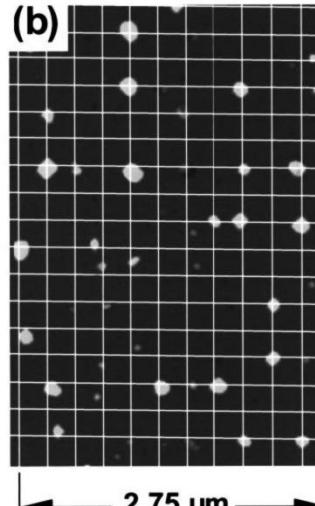
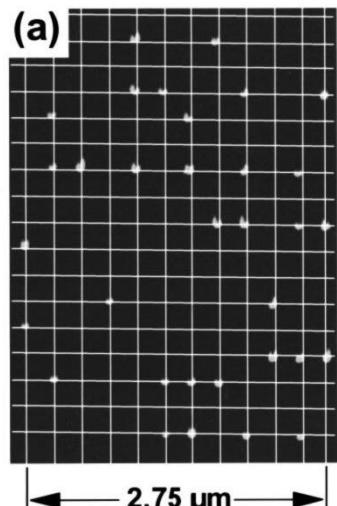
- Lithography + Etching + Annealing → holes

Au/Si



Y.Homma, Appl.Phys.Lett. **74**(6), 815 (1999)
T.Ogino, Surf.Sci.386, 137 (1997)

- Nanoimprint → Si mesas → Ge / Si



T.I.Kamins,
Appl.Phys.Lett.
74(12),
1773 (1999)

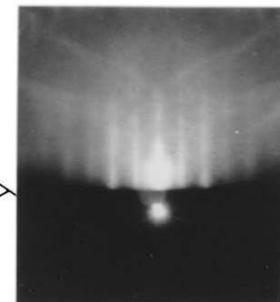
- In-situ lithography on oxide layer
InAs / GaAs

(a)

100 nm

3 μm

3 μm

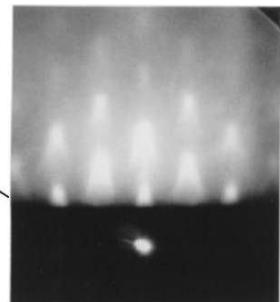


(d)

100 nm

3 μm

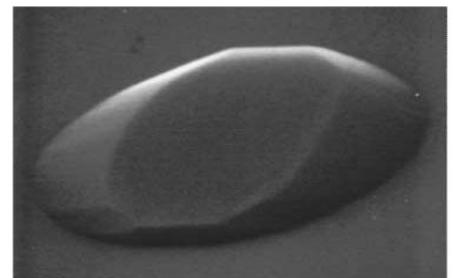
3 μm



T.Ishikawa, Appl.Phys.Lett. **73**(12),
1712 (1998)

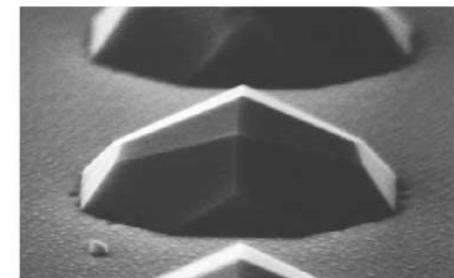
GaAs / GaAs

- **Step 1:** Deposition of SiO_2 layer
- **Step 2:** Ex-situ lithography on oxide layer, plus wet chemical etching
- **Step 3:** Growth of GaAs through windows, either in dot or antidot array.



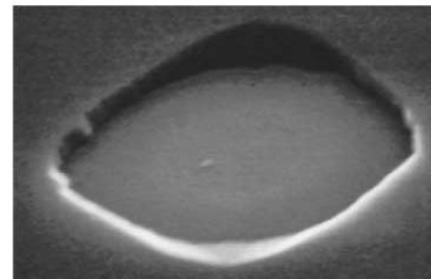
(a)

$2\mu\text{m}$



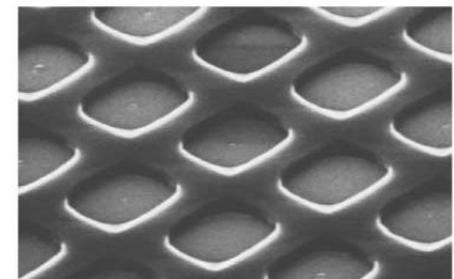
(b)

500nm



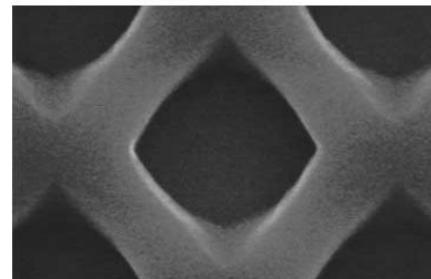
(c)

$2\mu\text{m}$



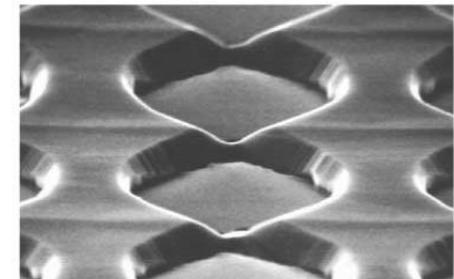
(d)

$2\mu\text{m}$



(e)

$1\mu\text{m}$



(f)

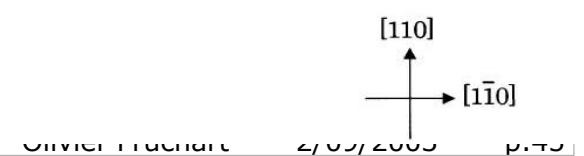
500nm



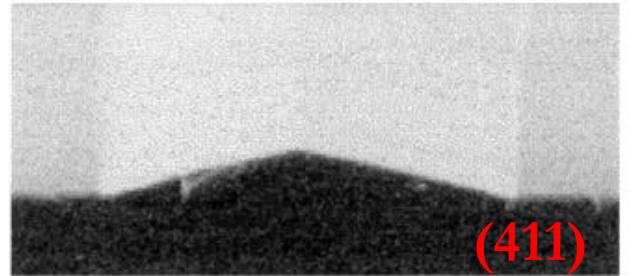
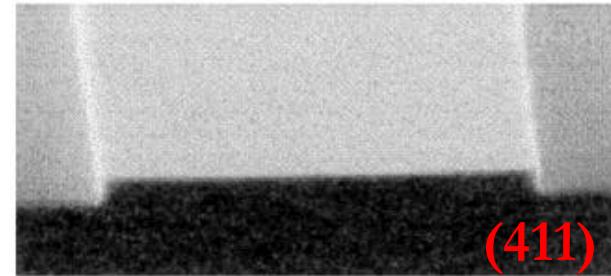
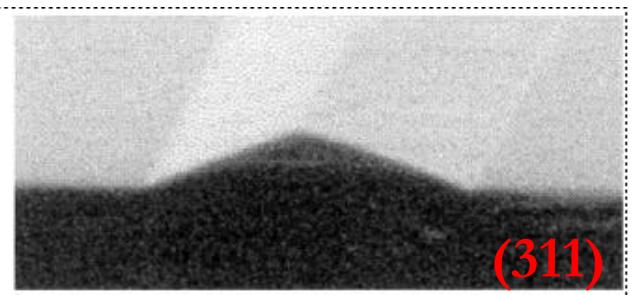
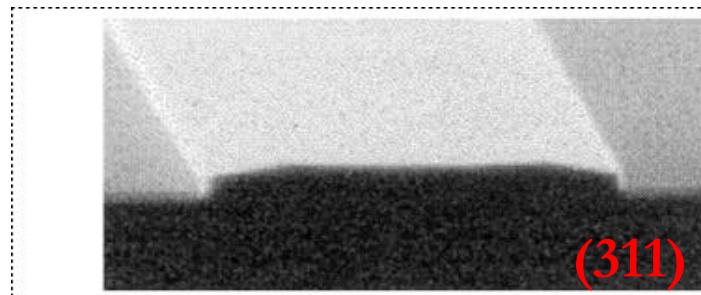
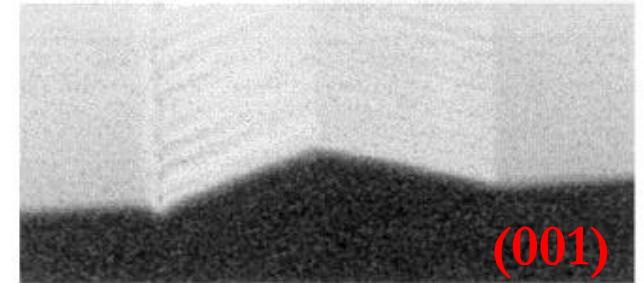
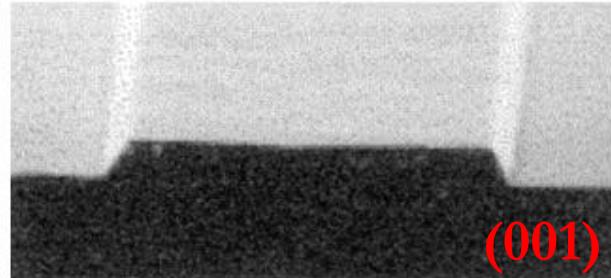
H. Hasegawa, J. Cryst. Growth 227-228, 1078 (2001)



Laboratoire Louis Néel, Grenoble, France.



GaAs / GaAs



{01-1}



{0-11}

(e)

3mm wide stripes



(f)

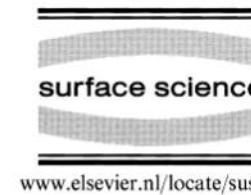
H. Hasegawa, J. Cryst. Growth 227-228, 1078 (2001)

Laboratoire Louis Néel, Grenoble, France.

Olivier Fruchart - 2/09/2003 - p.46



Surface Science 432 (1999) 37–53



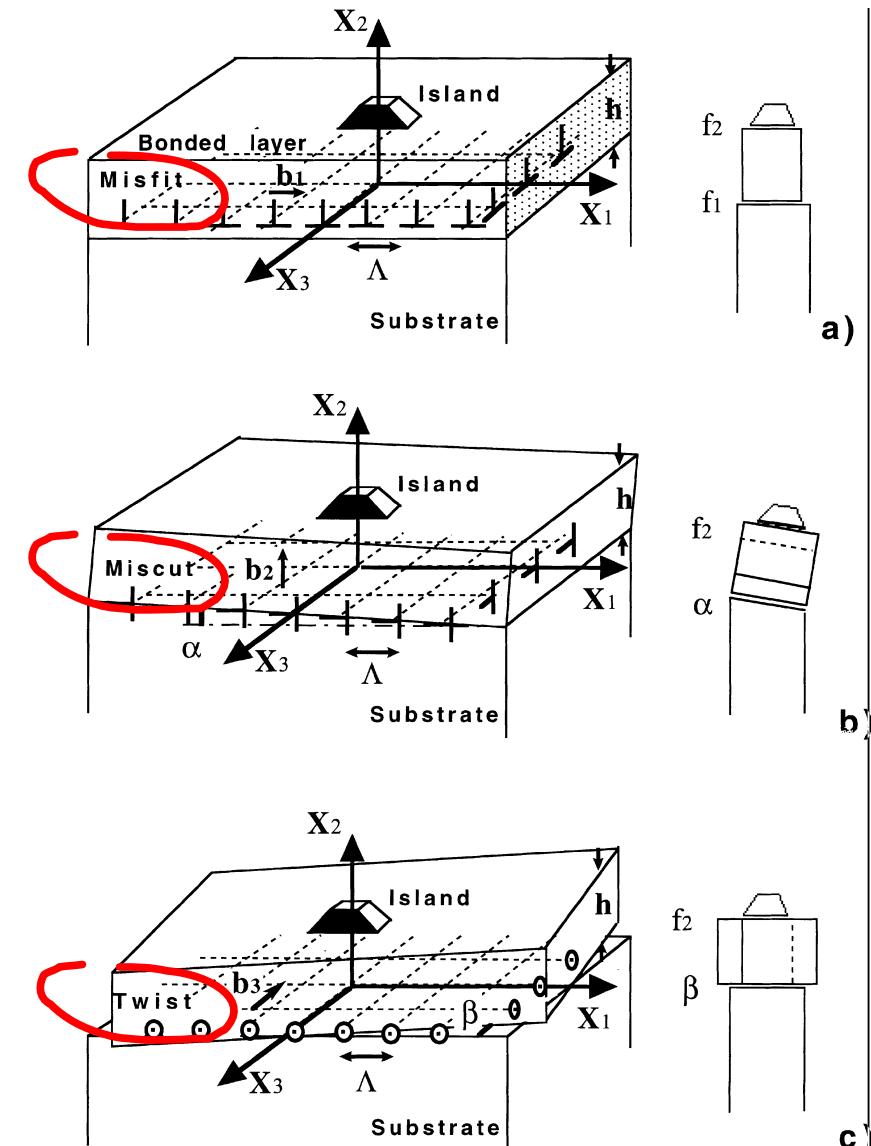
How to control the self-organization of nanoparticles by bonded thin layers

A. Bourret *

Département de Recherche Fondamentale sur la Matière Condensée, SP2M¹, CEA Grenoble, 17 rue des Martyrs 38054, Grenoble Cedex 9, France

Received 21 December 1998; accepted for publication 6 April 1999

- Substrate bonding and smart cut process.
 - ↳ array of dislocations arise from either:
 - Misfit
 - Miscut
 - Twist

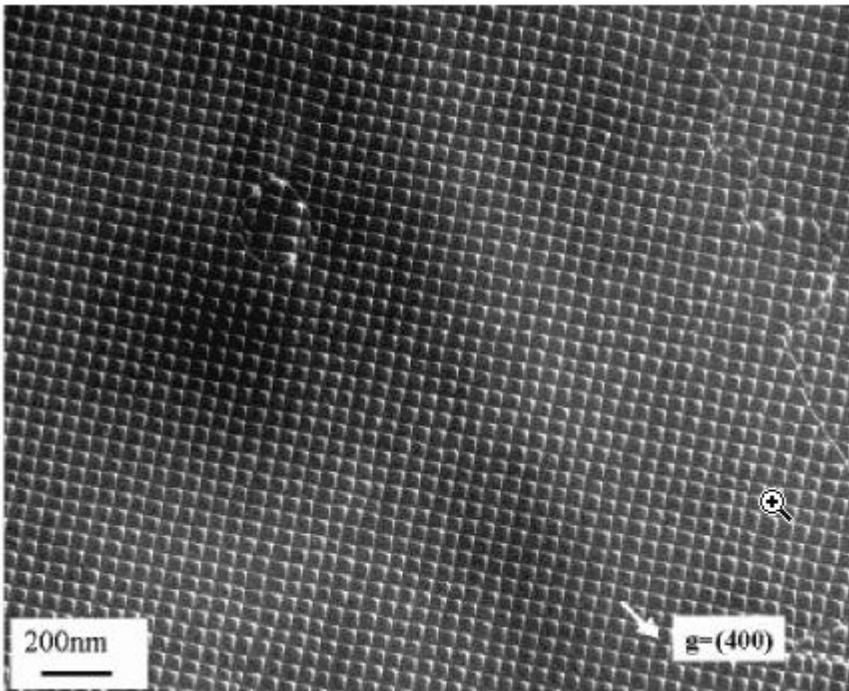


Laboratoire Louis Néel, Grenoble, France.

Olivier Fruchart - 2/09/2003 - p.47

Step 1: wafer bonding

Screw dislocations

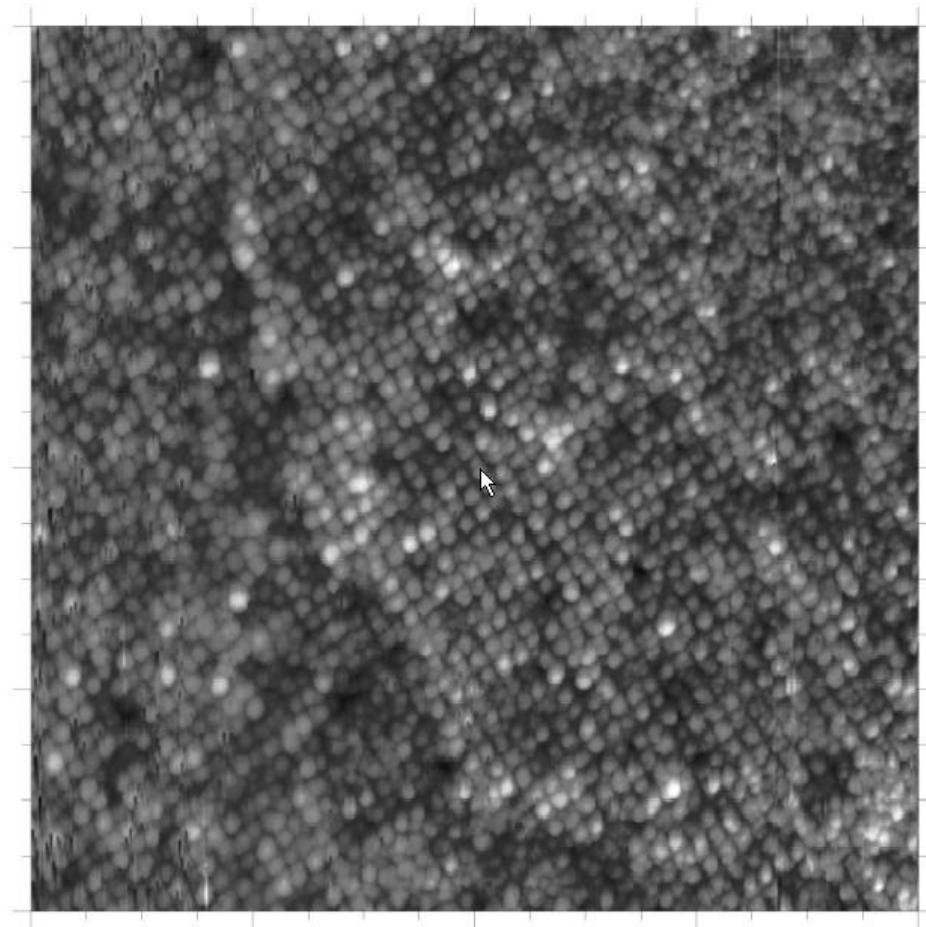


J. L. Rousseau et al., APL80, 4121 (2002)

CEA-Grenoble

Step 2: template for growth

1. Chemical etching > corrugation enhanced
2. Growth (here: Si)



J. Eymery, Habilitation (2003)

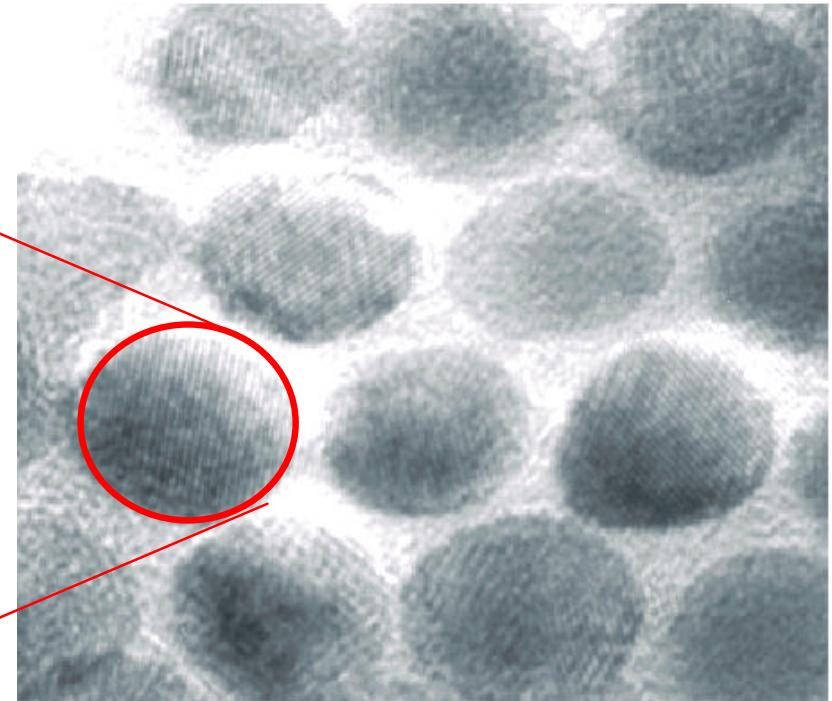
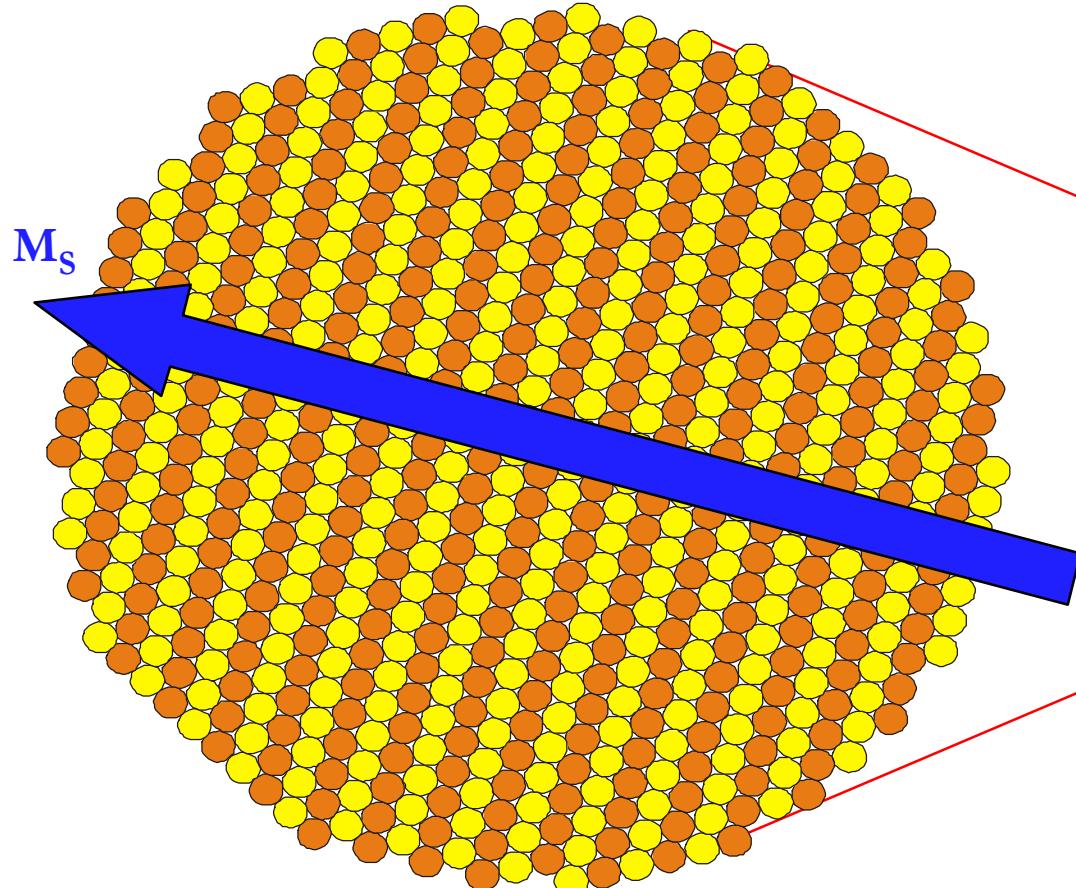


Laboratoire Louis Néel, Grenoble, France.

Olivier Fruchart - 2/09/2003 - p.48

<http://lab-neel.grenoble.cnrs.fr/themes/couches/ext/>

L1₀ phase : alternation of Fe and Pt monoatomic planes
→ extremely high magnetocrystalline anisotropy K



Random orientation of anisotropy axes



S. Sun, Science 287, 1989 (2000)

(Image: courtesy of D. Weller - Seagate via N. Dempsey - LLN/CNRS)

(1. Introduction)

2. Self-assembled epitaxial growth

3. Self-organized epitaxial growth

4. 3D self-organization via multilayer stacking

5. Perspectives of self-organization

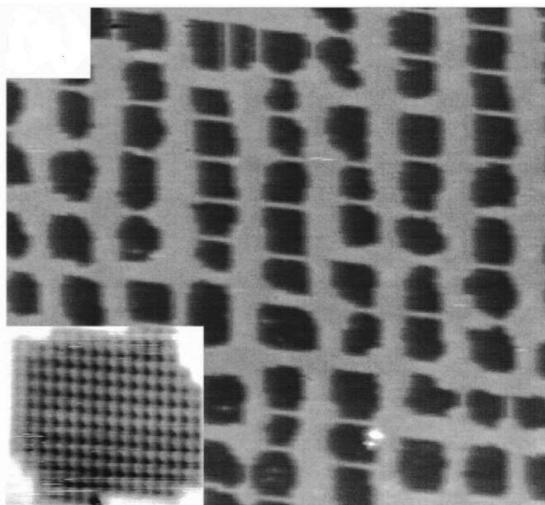
6. X-ray investigation of SO systems

References



SXRD: self-organized N/Cu(001)

0.2AL N/Cu(001)

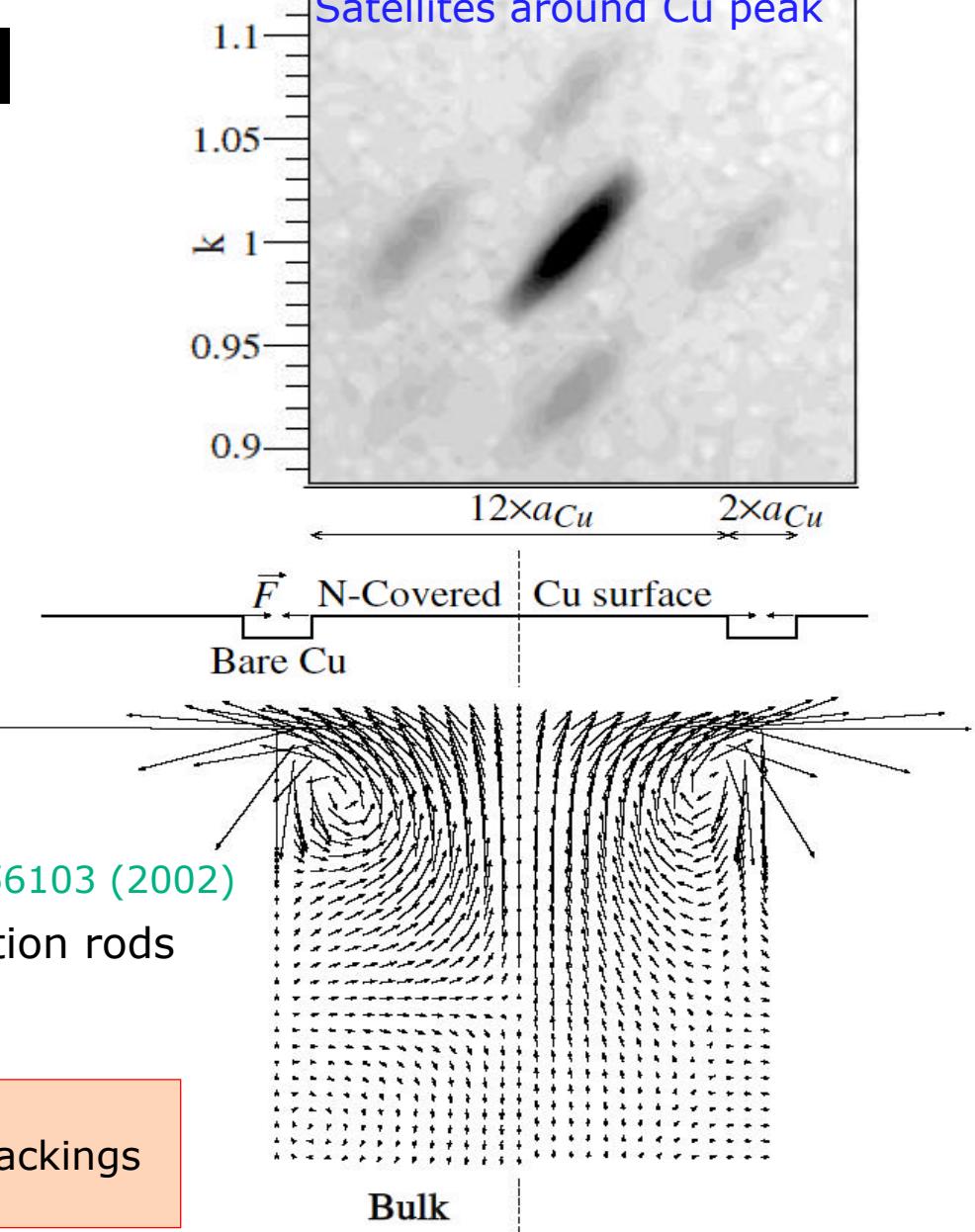


S.L. Silva, APL76, 1128 (2000)
 F.M. Leibsle, SS317, 309 (1994)

B. Croset, PRL88, 056103 (2002)

Periodic surface strain give rise to satellite diffraction rods

Satellites around Cu peak

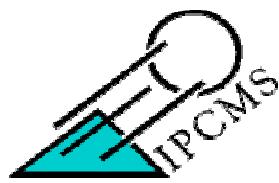
**Other groups:**

- T. Metzger (ESRF, Grenoble): Quantum dots stackings
- J. Eymery (CEA Grenoble): wafer bonding

Collaborators



G. Renaud, M. Noblet, O. Ulrich
DRFMC/SP2M/IRS (CEA), Grenoble



J.-P. Deville, A. Barbier, F. Scheurer, J. Mané-Mané
IPCMS (CNRS/ULP/ECPM), Strasbourg



V. Repain, G. Baudot, S. Rousset
GPS-Jussieu, Paris



Laboratoire Louis Néel, Grenoble, France.

Olivier Fruchart - 2/09/2003 - p.52

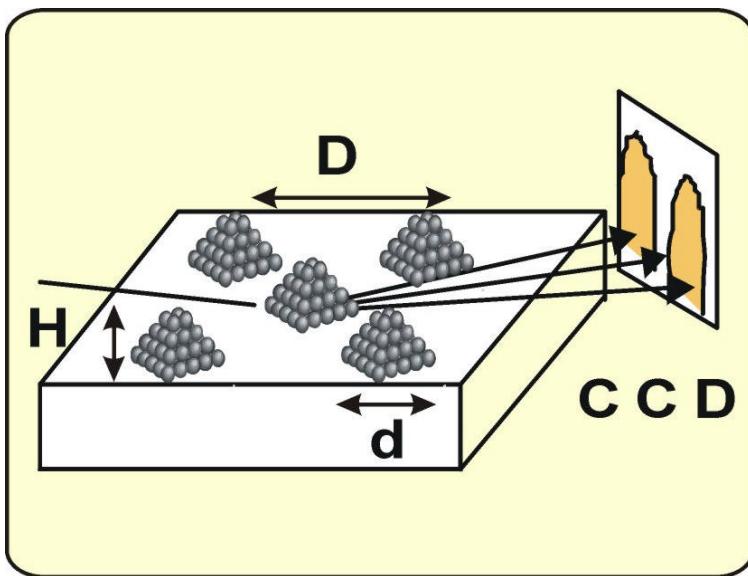
<http://lab-neel.grenoble.cnrs.fr/themes/couches/ext/>

GISAXS: Grazing Incidence Small Angle X-ray Scattering

Objects >> atoms

Surface sensitive

PRINCIPLE



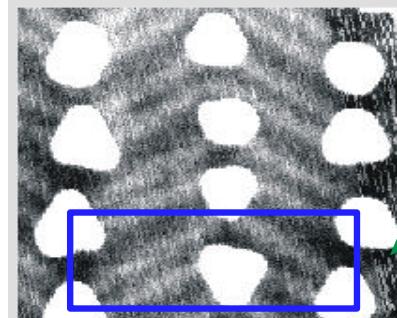
- In-plane / out-of-plane diffusion
- Probes size (H, d), shape, correlations

TECHNICAL ASPECTS

- ID32 beamline at ESRF
- In-situ under UHV:
 - real time
 - background subtraction
- No window before sample : low background

G. Renaud et al., Science 300, 1416 (2003)

O. Fruchart et al., Europhys. Lett. 63, 275 (2003)

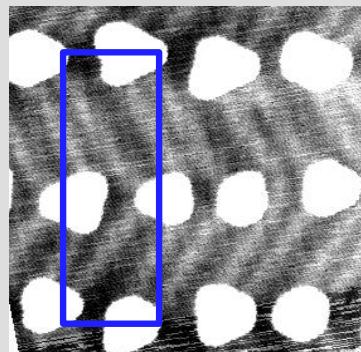


CCD

Thickness: 1 Å ; coverage: 25%

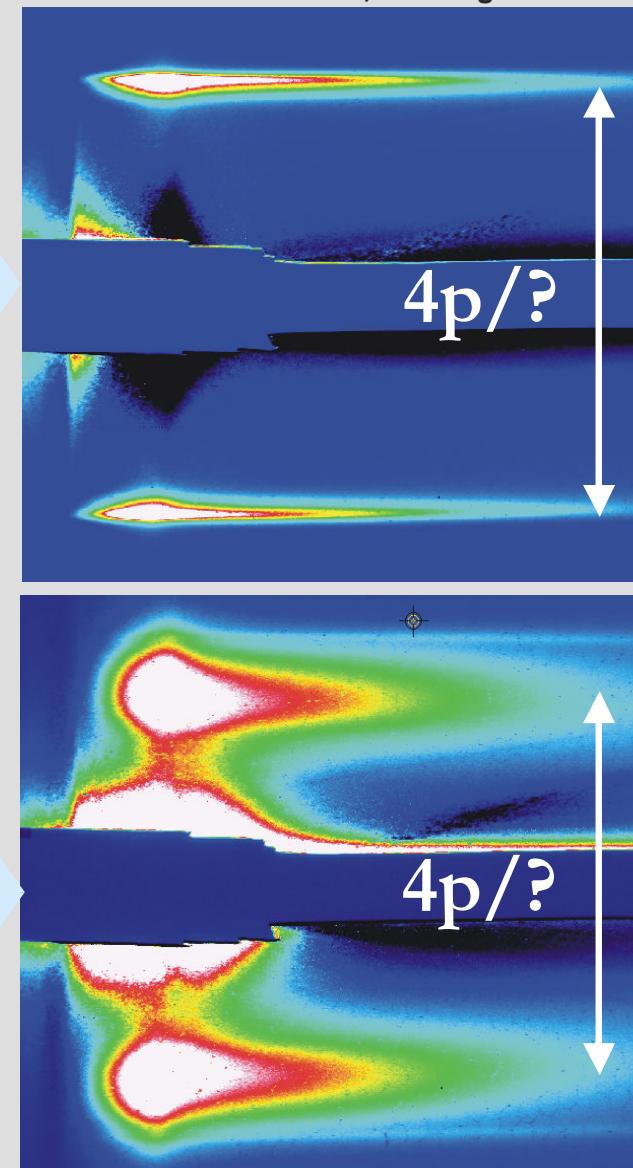
?

k



2?

k_1



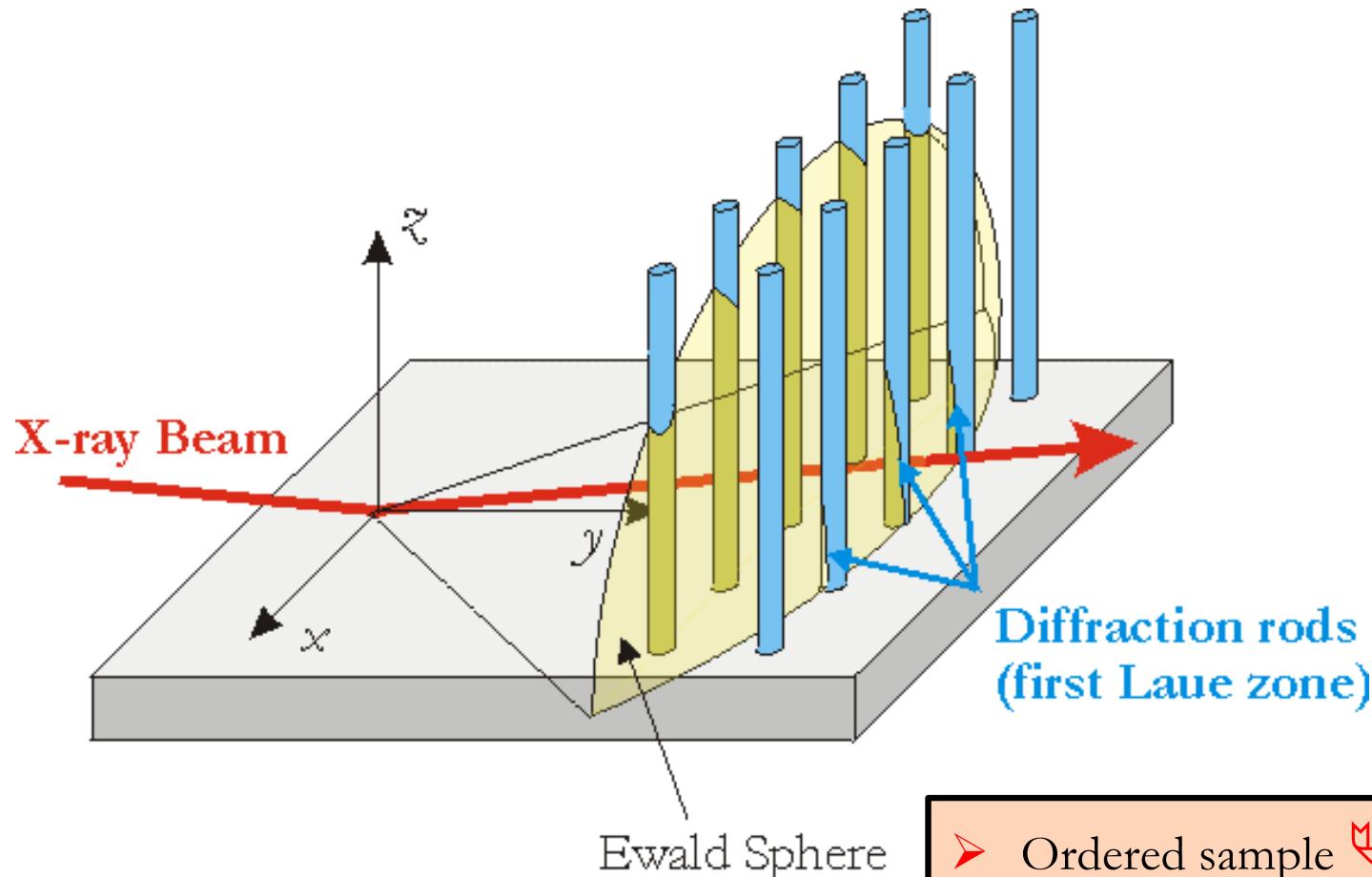
INTRAROW
ORDER:
SUPER-CRYSTAL

$$\Delta Q/Q = 3\%$$

INTER-ROW
ORDER:
LIQUIDE-TYPE

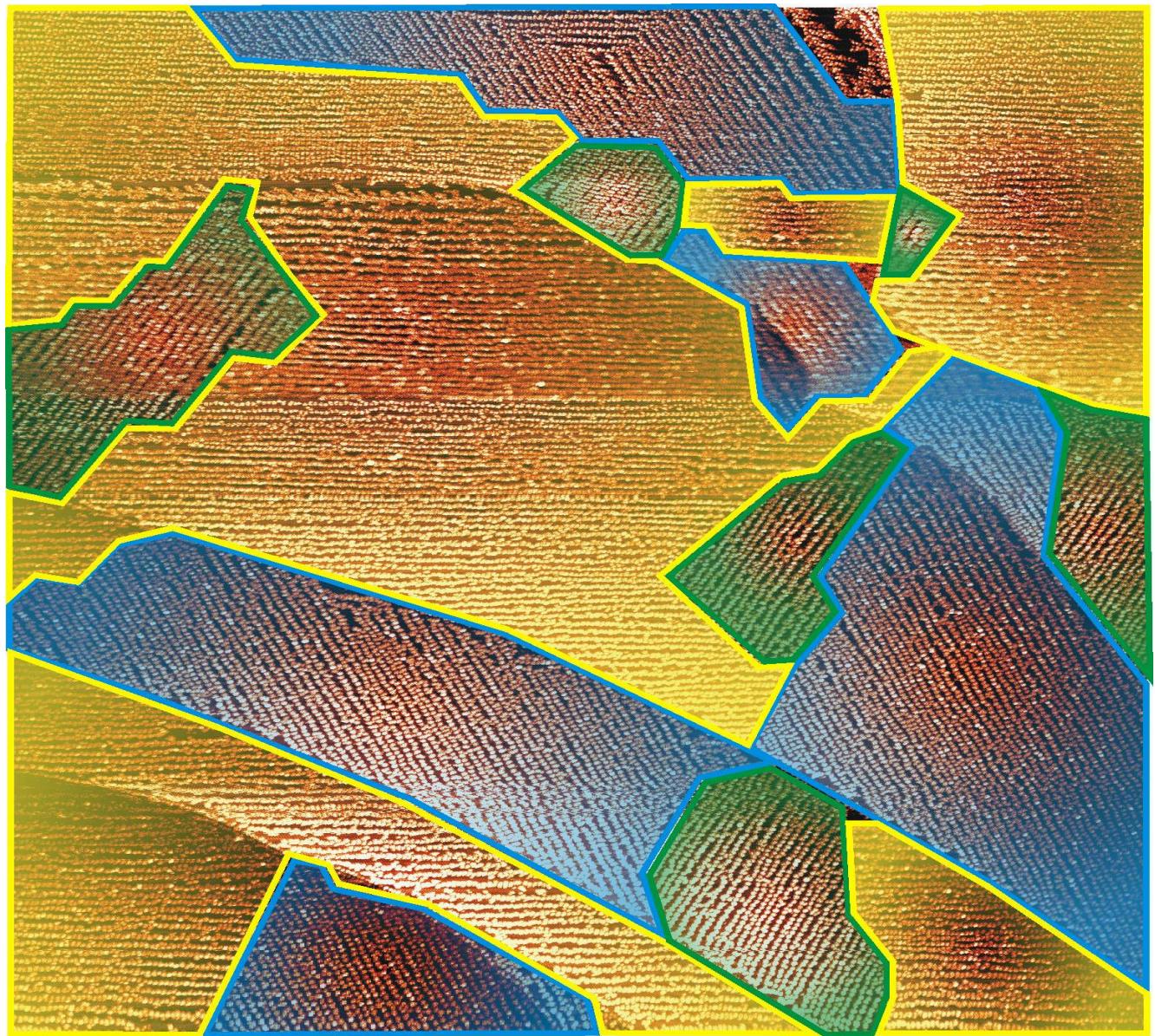
$$K=8.5 \text{ nm}$$

$$s=2.1 \text{ nm}$$



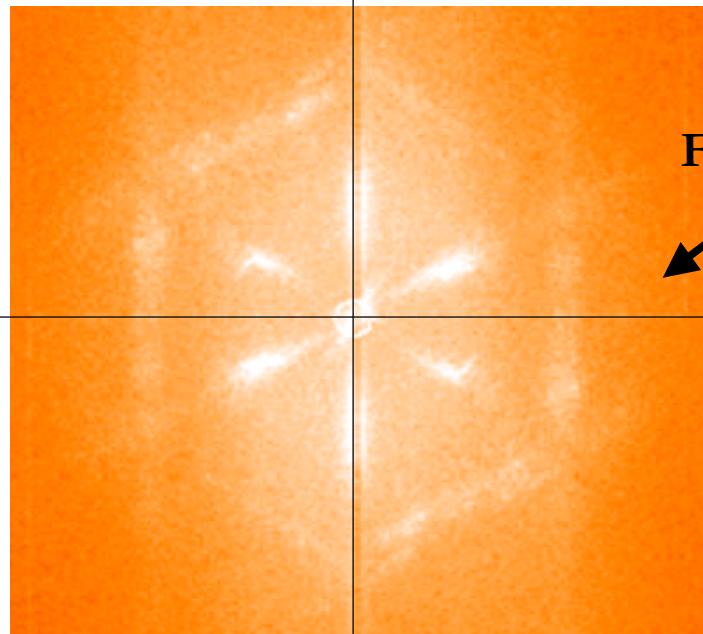
- Ordered sample ↗ ‘super’ reciprocal space ?
- Grazing incidence and 2D detector
↗ similarity with RHEED

1.5mm x 1.5mm STM image

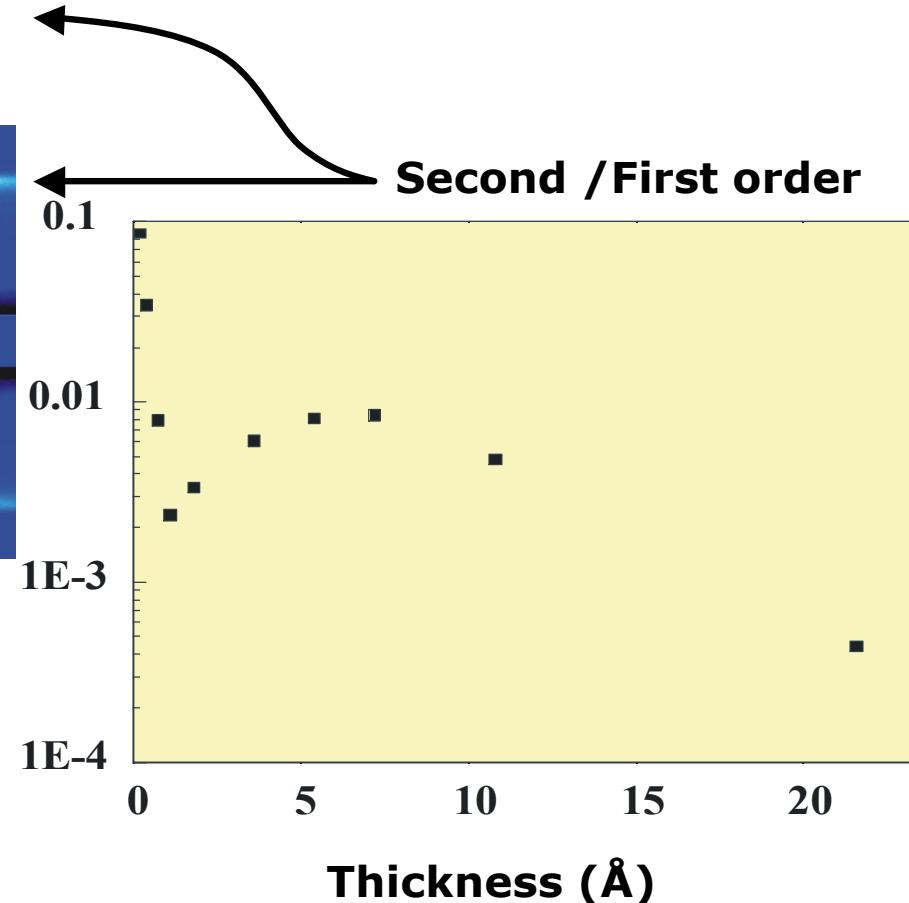
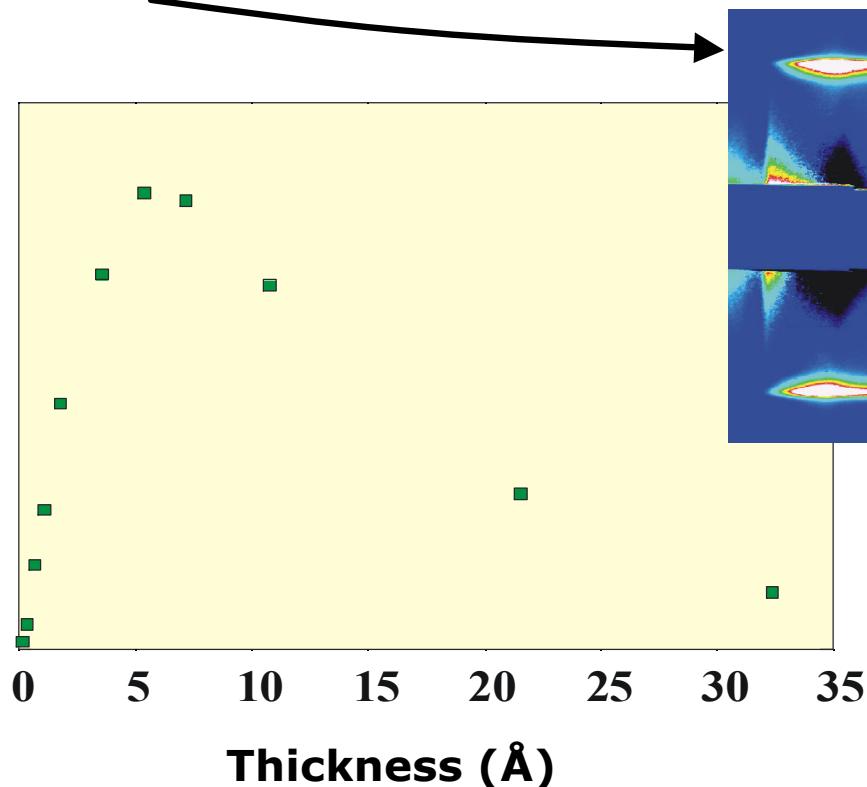


3-fold symmetry of Au(111) crystal

- 3 ‘equivalent domains’



First order peak intensity



Features to explain

- ⇒ Maximum at 6\AA = 3 atomic layers ?
- ⇒ Significant intensity for continuous film ?

- ⇒ Weak intensity ?
- ⇒ Intermediate minimum ?

RATIO: Second /First order peak intensity

➤ Deposition rate calibration

Simple model of 1D coalescence

